

Design Insights from Electromagnetic Analysis of Interconnects

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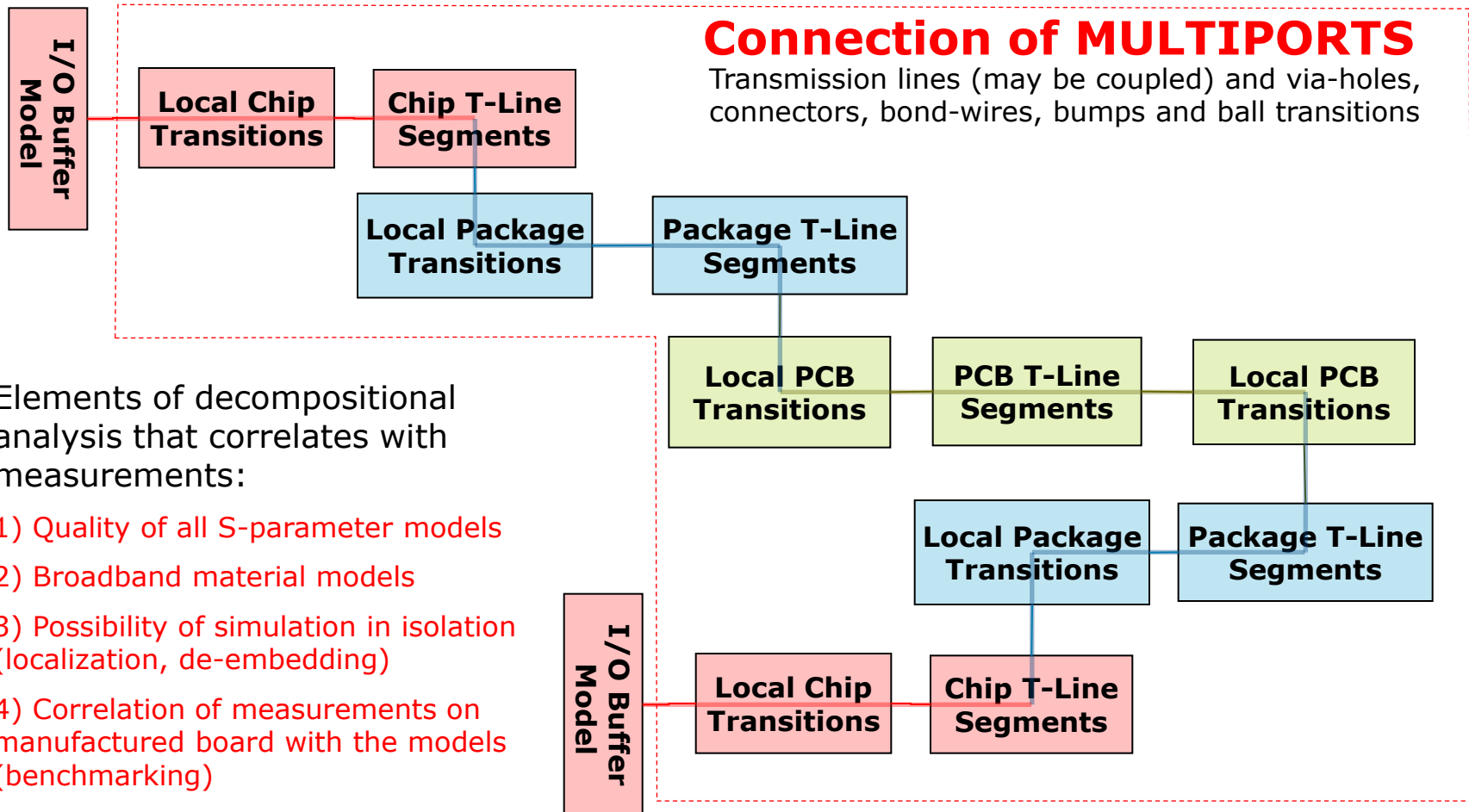
Outline

- Introduction
- Decompositional electromagnetic analysis
- Broadband material models
 - Dielectric and roughness models and model identification
 - Nickel model in ENIG plated traces
- Modeling discontinuities
 - Planar transitions - control of impedance and skew
 - Vertical transitions – localization and crosstalk
- Conclusion
- References and contacts

Introduction

- ❑ Data links running at bitrates 10-30 Gbps and beyond are becoming the mainstream in the communication and other electronic systems
- ❑ Why is design of PCB and packaging interconnects for such systems is a challenging problem?
 - It requires electromagnetic analysis over extremely broad frequency bandwidth from DC to 20-50 GHz
 - No frequency-continuous dielectric models available from laminate manufactures
 - No roughness models available from manufacturers
 - Boards are routed in old-style ways based on rules and approximate models and not on EM analysis
 - Boards are not manufactured as designed – large variations and manipulations by manufacturer
- ❑ Is it possible to design and build interconnects and have acceptable analysis to measurement correlation from DC to 20-50 GHz systematically?
 - Obviously yes, but only if some conditions are satisfied
 - The conditions are partially covered here and discussed in detail in my tutorial at DesignCon 2013 and in paper presented at EMC 2013 symposium (both available at www.simberian.com)
 - This presentation provides practical examples illustrating how to make decisions on the base of EM analysis
 - Some examples may look counter-intuitive ☺

Decompositional analysis of a channel



Quality of S-parameter models

- ❑ Multiports are usually described with S-parameter models
 - Produced by circuit or electromagnetic simulators, VNAs and TDNAs in forms of Touchstone or BB SPICE models
- ❑ Very often such models have issues and may be not suitable for consistent frequency and time domain analyses
 - Not sufficient bandwidth and sampling
 - Passivity, reciprocity and causality conditions may be violated
- ❑ How to make sure that a model is suitable for analysis?
 - **The answer is one of the key elements for design success**
 - To make the decision easier, Passivity, Reciprocity and Causality quality metrics has been introduced in 2010 and implemented in Simbeor software
 - See references on quality of S-parameters at the end of presentation
- ❑ All models for this presentation are created with Simbeor software
 - Adaptively sampled, reciprocal, passive and causal
 - With bandwidth 50 GHz for 30 Gbps, 16 ps rise time

Broadband material models

- ❑ The largest part of interconnects are transmission line segments
- ❑ Models for transmission lines are usually constructed with a quasi-static or electromagnetic field solvers
 - T-lines with homogeneous dielectrics (strip lines) can be effectively analysed with quasi-static field solvers
 - T-lines with inhomogeneous dielectric may require analysis with a full-wave solver to account for the high-frequency dispersion
- ❑ Accuracy of transmission line models is mostly defined by **availability of broadband dielectric and conductor roughness models**
- ❑ **This is the most important elements for design success**

Causal dielectric models for PCB and PKG

- Multi-pole Debye-Lorentz (real and complex poles)

$$\varepsilon(f) = \varepsilon(\infty) + \sum_{n=1}^N \frac{\Delta\varepsilon_n}{1 + i \frac{f}{f_r_n}} + \sum_{k=1}^K \frac{\Delta\varepsilon_k \cdot f r_k^2}{f r_k^2 + 2i \cdot f \cdot \frac{\delta_k}{2\pi} - f^2}$$

Requires specification of value at infinity and poles/residues/damping or DK and LT at multiple frequency points

- Wideband Debye (Djordjevic-Sarkar)

$$\varepsilon(f) = \varepsilon_r(\infty) + \frac{\varepsilon_{rd}}{(m_2 - m_1) \cdot \ln(10)} \cdot \ln \left[\frac{10^{m_2} + if}{10^{m_1} + if} \right]$$

Continuous-spectrum model
Requires specification of DK and LT at one frequency point

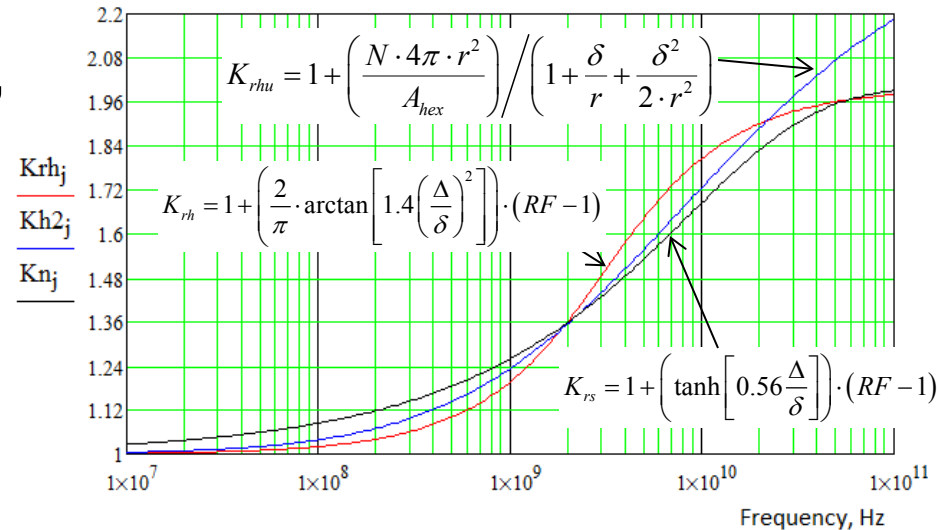
- Models for dielectric mixtures (Wiener, Maxwell-Garnet, ...)
- Models for anisotropic dielectrics (separate definition of Z, and XY-plane components of permittivity tensor)

Parameters of the causal models are not available from manufacturers!

Causal roughness models

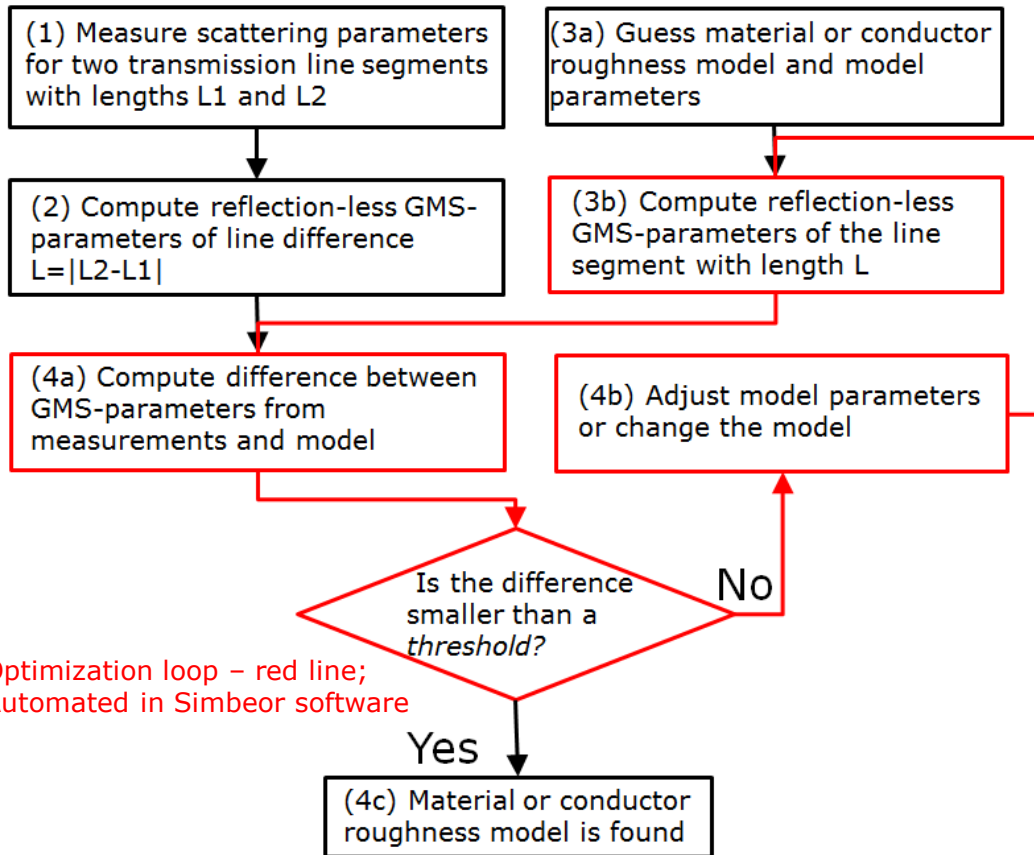
- Modified Hammerstad (red), Simbeor (black) and Huray's snowball (blue) models (RTF/TWS foil example)

See references in the papers (Shlepnev, EMC2012 and DC2012)



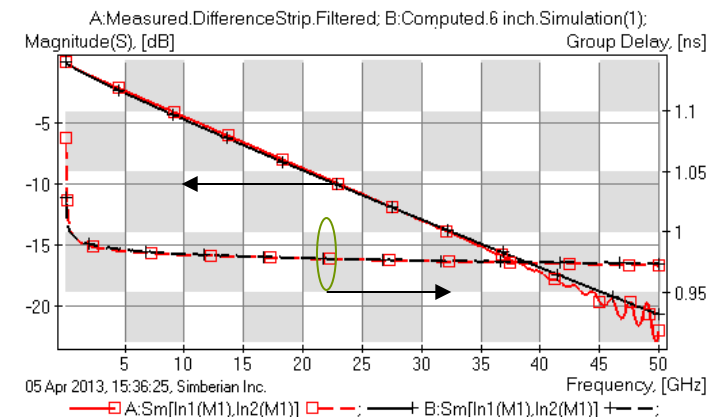
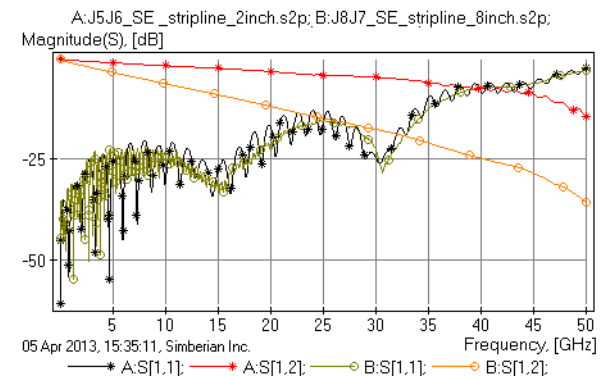
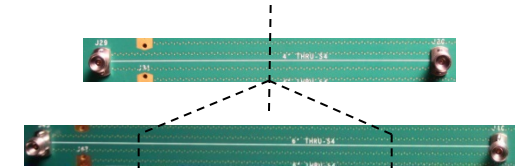
- Causal if correction is applied to conductor surface impedance operator
- Where to get the model parameters?
 - SR (delta) and RF for Simbeor and MHCC
 - Number of balls, ball size and tile area for Huray's model

Material parameters identification with generalized modal S-parameters (GMS-parameters)

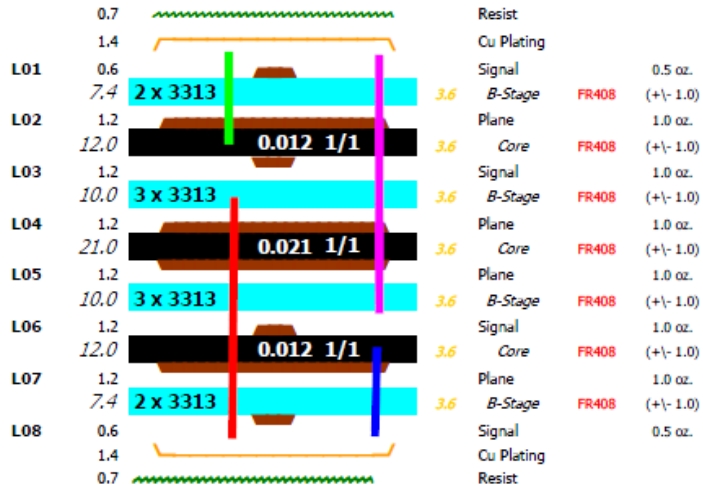


Optimization loop – red line;
Automated in Simbeor software

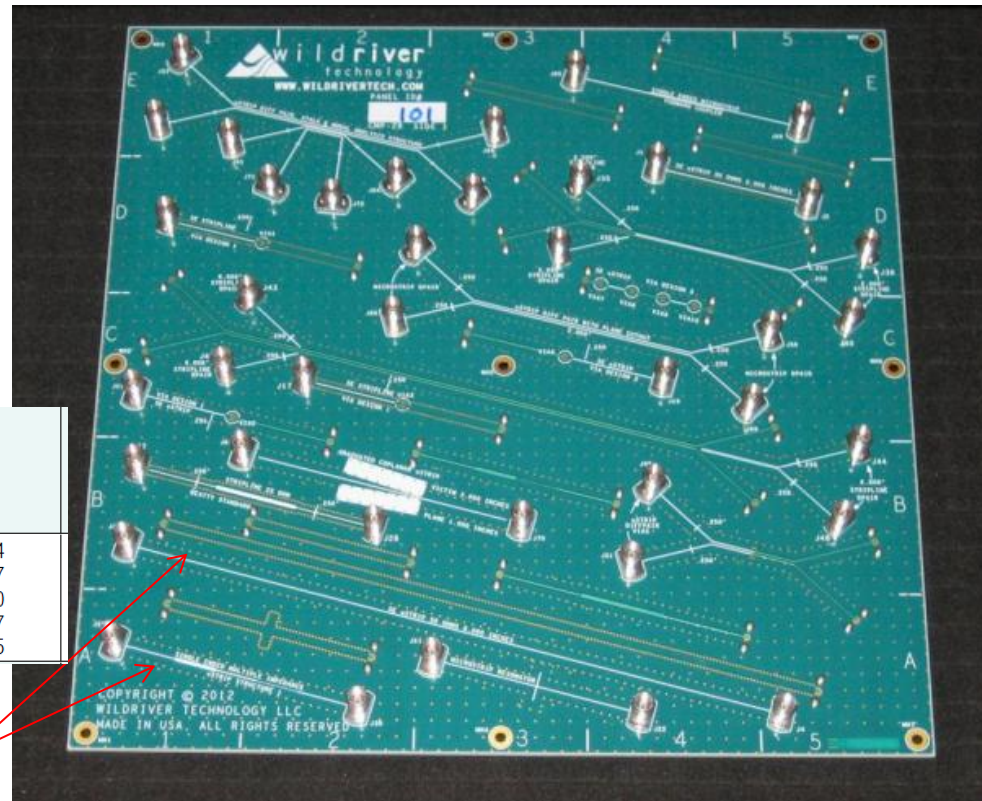
Can be used to identify both dielectric and conductor roughness models
Simberian's patents pending **#13/009,541** and **#14/045,392**



Board for material models identification example



CMP-28 validation board designed and investigated by Wild River Technology <http://wildrivertech.com/>

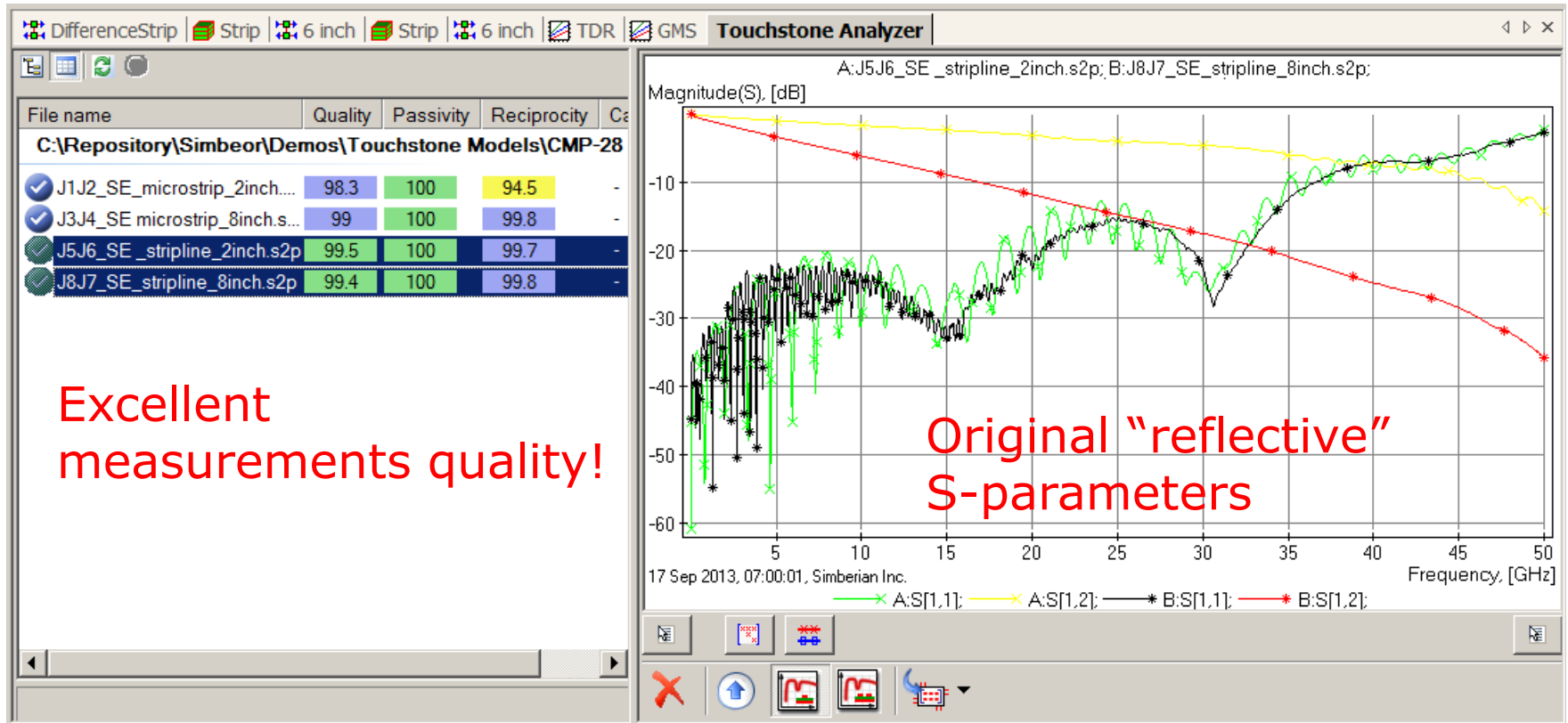


From Isola FR408 specifications

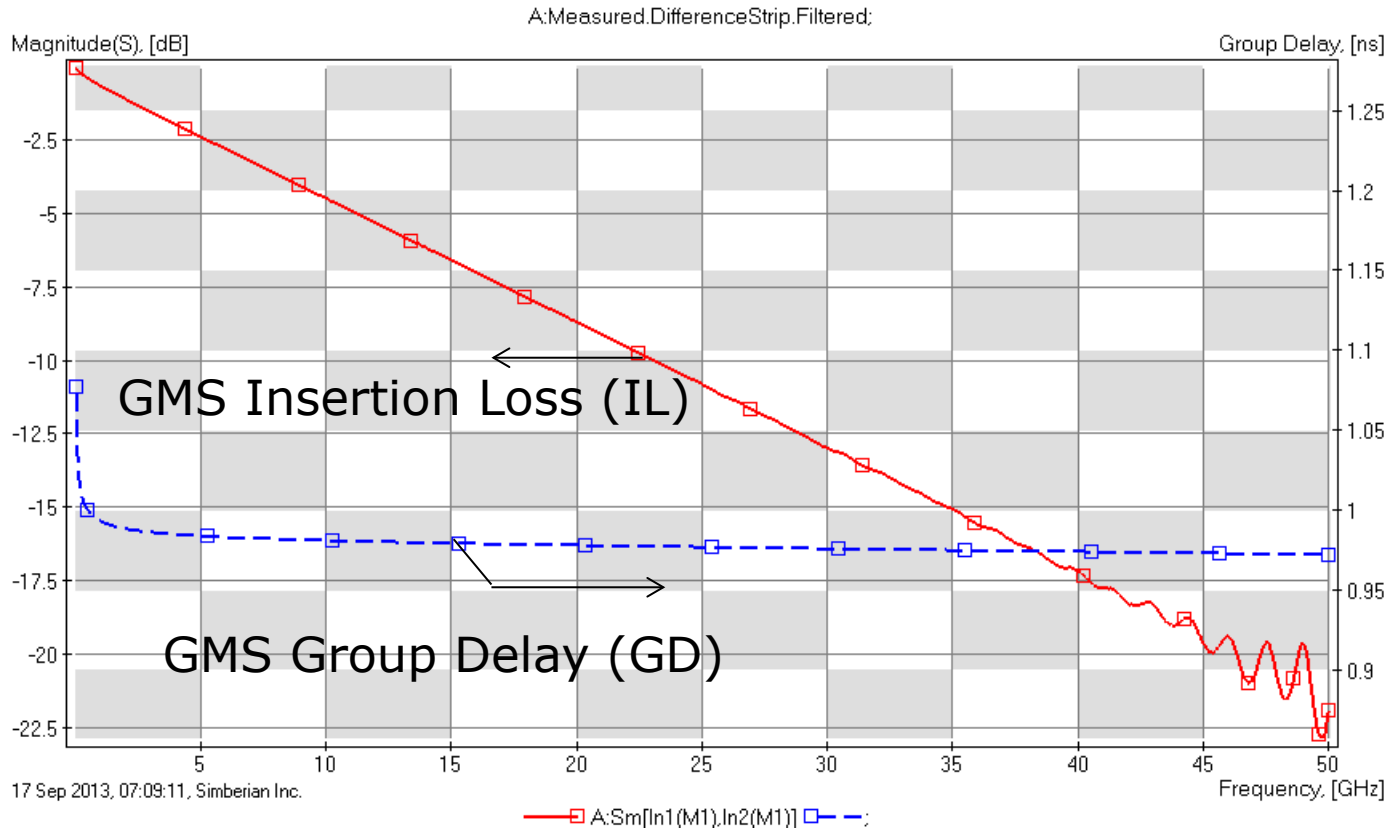
Dk, Permittivity (Laminate & prepreg as laminated) Tested at 56% resin	A. @ 100 MHz (HP4285A)	3.69
	B. @ 1 GHz (HP4291A)	3.66
	C. @ 2 GHz (Bereskin Stripline)	3.67
	D. @ 5 GHz (Bereskin Stripline)	3.66
	E. @ 10 GHz (Bereskin Stripline)	3.65
Df, Loss Tangent (Laminate & prepreg as laminated) Tested at 56% resin	A. @ 100 MHz (HP4285A)	0.0094
	B. @ 1 GHz (HP4291A)	0.0117
	C. @ 2 GHz (Bereskin Stripline)	0.0120
	D. @ 5 GHz (Bereskin Stripline)	0.0127
	E. @ 10 GHz (Bereskin Stripline)	0.0125

10.5-11 mil wide strip lines,
Use measured S-parameters for
2 segments (2 inch and 8 inch)

Measured S-parameters for 2 and 8 inch segments



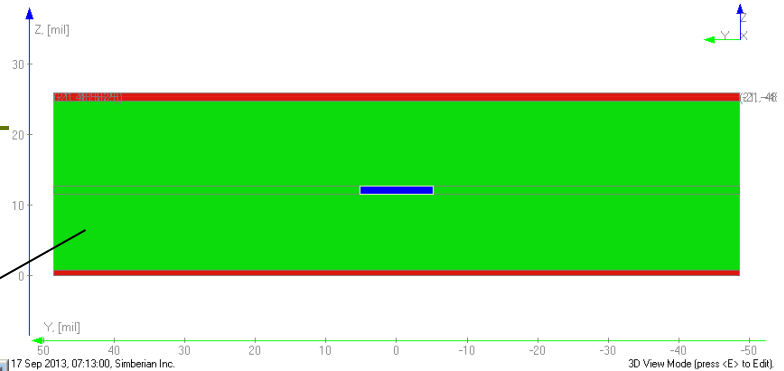
GMS-parameters computed from the original S-parameters



Reflection in generalized modal S-parameters is exactly zero
– makes material model identification much easier!

Material models for strip line analysis - definition

First, try to use material parameters from specs



Material [?] [X]

Insulator Appearance

Name:

Polarization Loss Model

Type:

Specify permittivity and loss tangent at the measurement frequency. Loss tangent is slowly growing in the frequency band defined by WD Low and High Frequencies... Suitable for FR4-type dielectrics.

Relative Permittivity (Dk):

Loss Tangent (Df or LT):

Measurement Frequency: [Hz]

Advanced Settings:

WD Low Frequency: [Hz]

WD High Frequency: [Hz]

Bulk Conductivity: [S/m] Relative Permeability:

OK Cancel

Dk, Permittivity (Laminate & prepreg as laminated) Tested at 56% resin		
A. @ 100 MHz (HP4285A)		3.69
B. @ 1 GHz (HP4291A)		3.66
C. @ 2 GHz (Bereskin Stripline)		3.67
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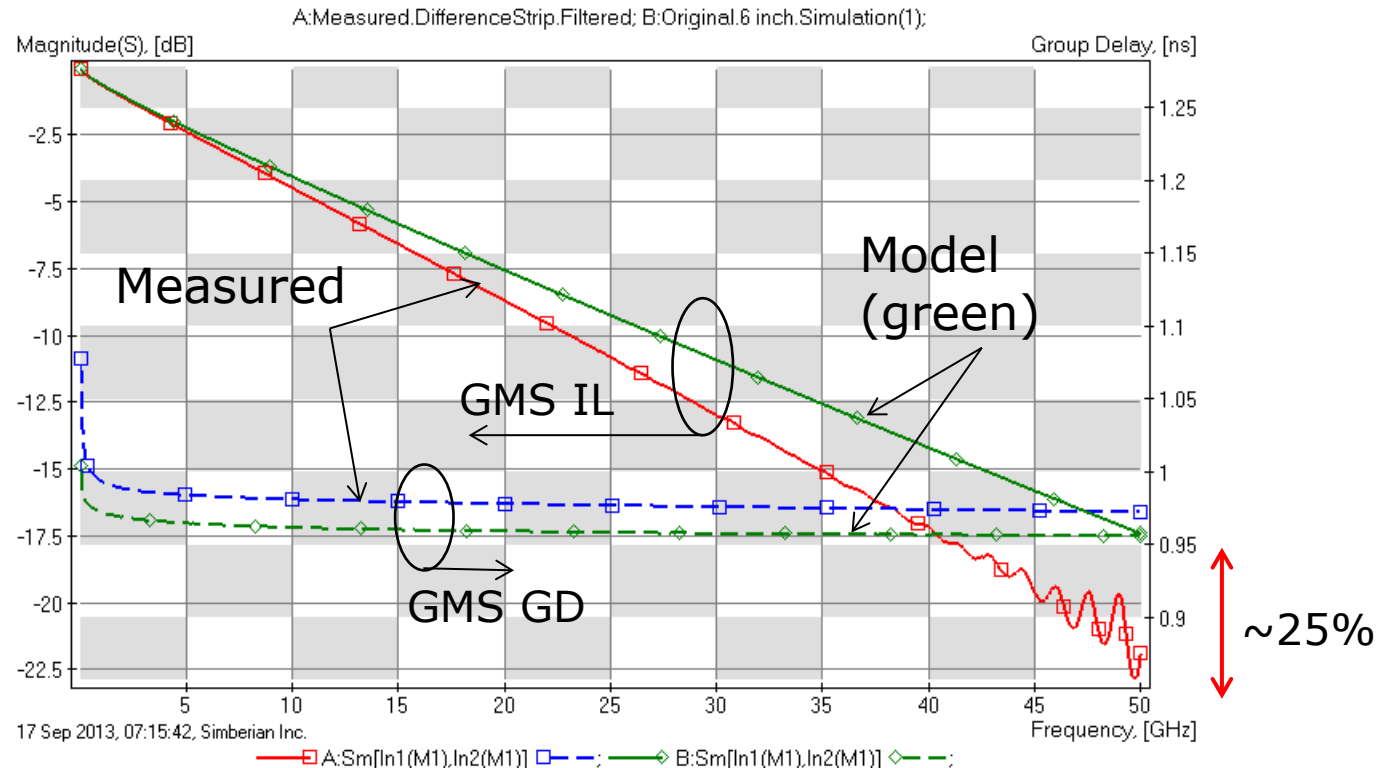
Wideband Debye model can be described with just one Dk and LT

$$\epsilon(f) = \epsilon_r(\infty) + \frac{\epsilon_{rd}}{(m_2 - m_1) \cdot \ln(10)} \cdot \ln \left[\frac{10^{m_2} + if}{10^{m_1} + if} \right]$$

Conductor is copper, no roughness in specs

Results with the original material models

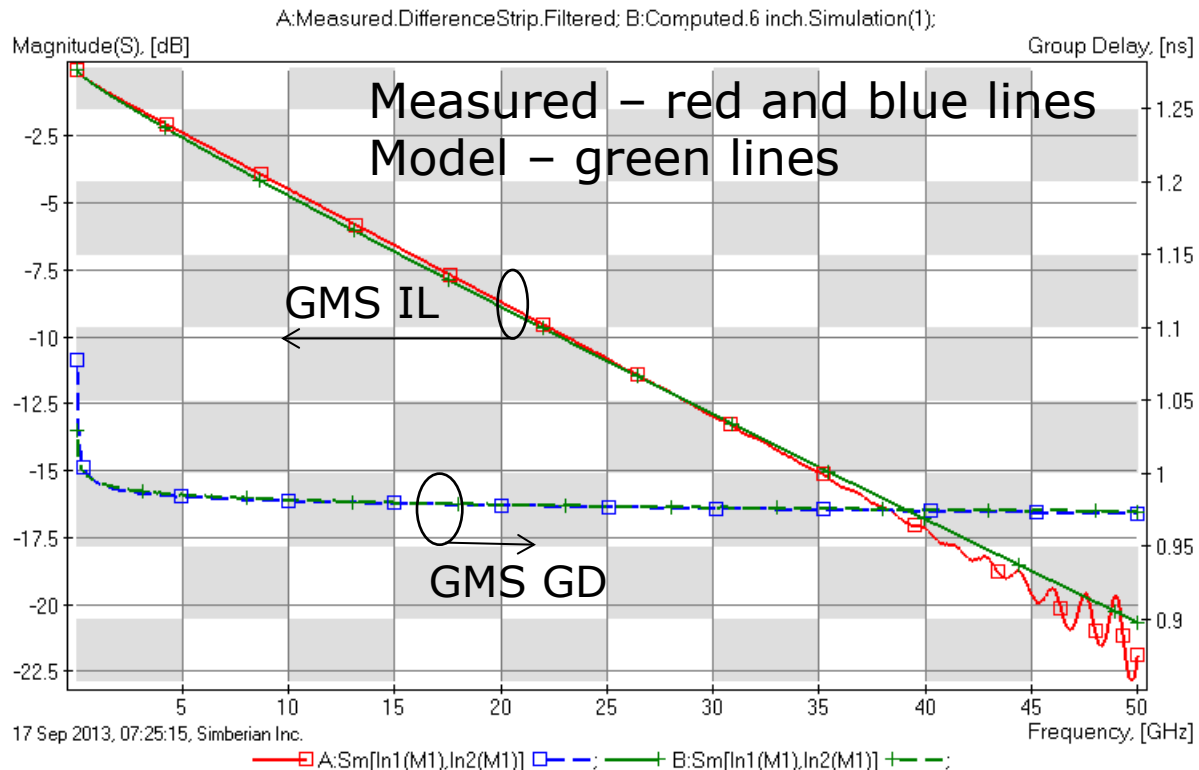
The original model produces considerably lower insertion losses (GMS IL) above 5 GHz and smaller group delay (GMS GD) at all frequencies:



- Two options:** 1) Increase Dk and LT in the dielectric model;
2) Increase Dk in dielectric model and model conductor roughness

Option 1: Increase Dk and LT in dielectric model (no conductor roughness)

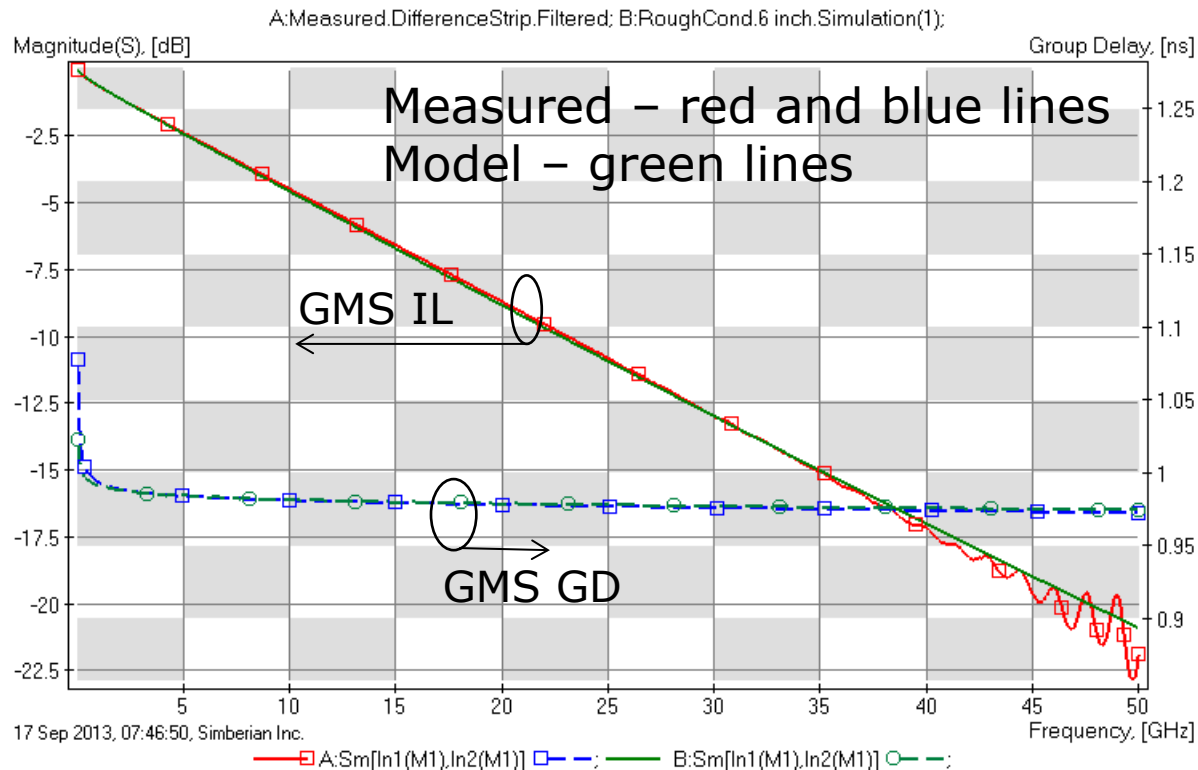
Good match with: Dk=3.83 (4.6% increase),
LT=0.0138 (18% increase), Wideband Debye model



Good match, but what if conductors are actually rough?

Option 2: Increase Dk and model conductor roughness (proper modeling)

Dielectric: $D_k=3.8$ (3.8% increase), $LT=0.0117$ (no change), Wideband Debye model
Conductor: Modified Hammerstadt model with $SR=0.32 \mu\text{m}$, $RF=3.3$

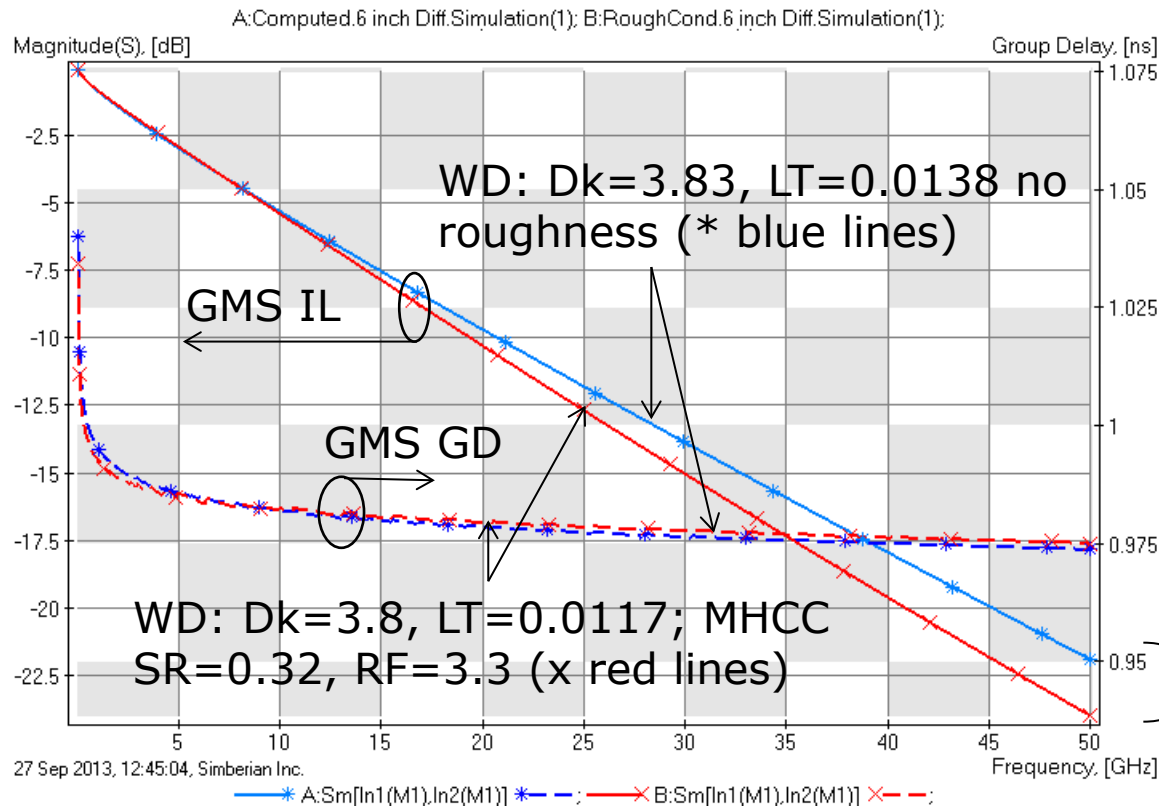
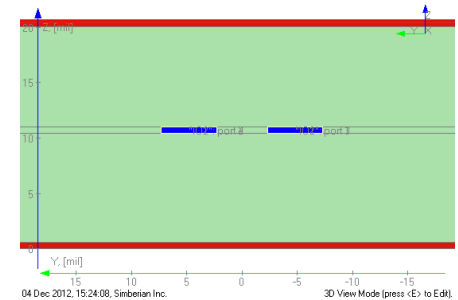


Excellent match and proper dispersion and loss separation!
This model is expected to work for strips with different widths

Can we use models for another cross-section?

- Differential 6 mil strips, 7.5 mil distance

GD is close, but the loss is different:



Which one is better?

About 10% difference for medium-loss dielectric

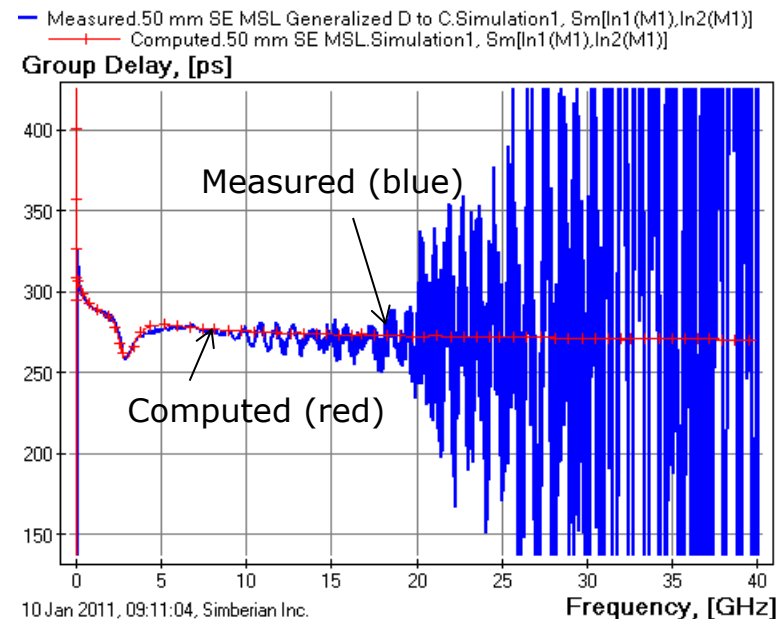
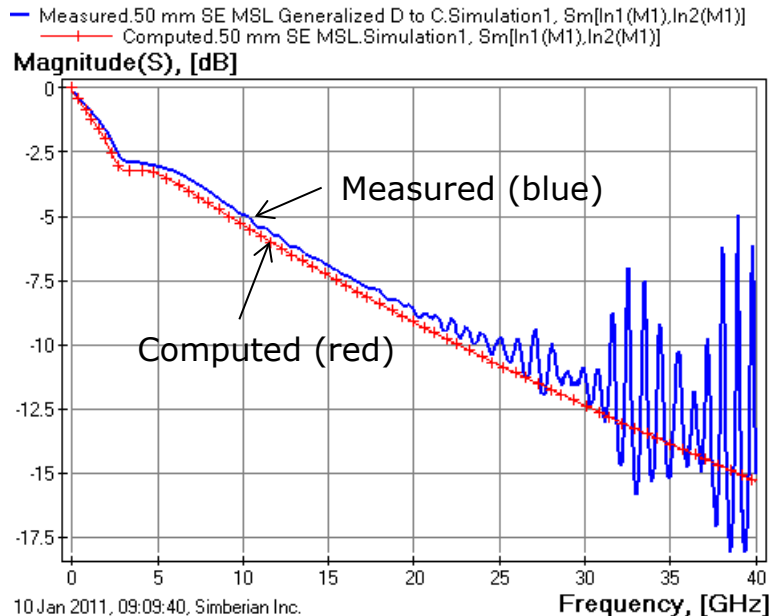
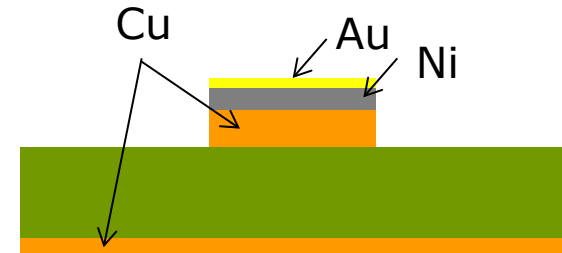
Plated nickel model identification

- Adjust Ni model parameters to match measured and computed GMS-parameters for 50 mm segment of microstrip line, strip width 69 μm , thickness 12 μm

ENIG finish with about 0.05 μm of Au and about 6 μm of Ni over the copper

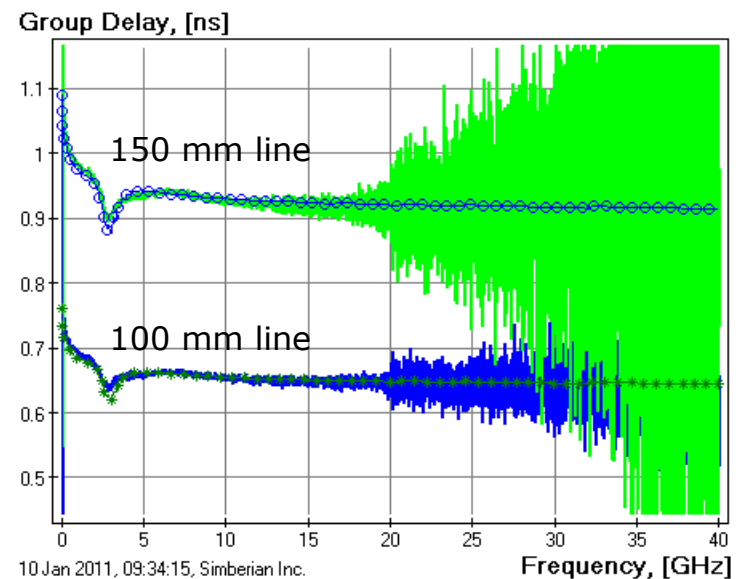
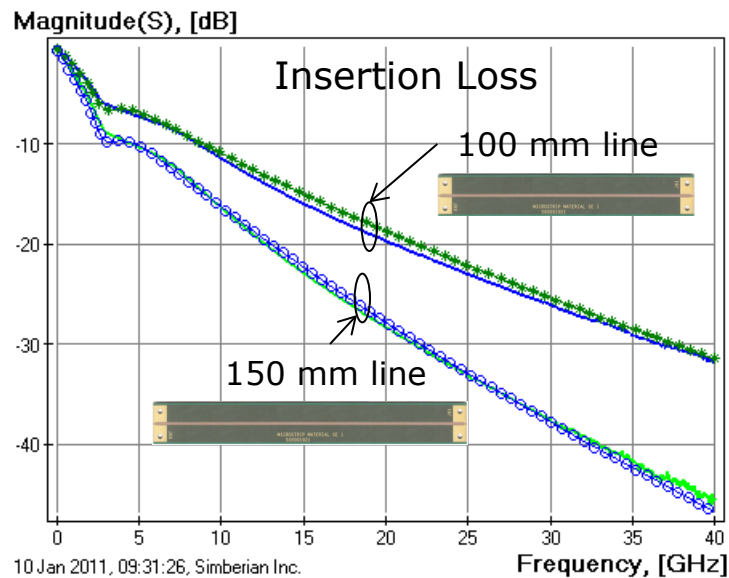
Substrate dielectric $DK=3.x$ and $LT=0.01x$ at 1 GHz, wideband Debye model

Landau-Lifshits model for Nickel: $Mu_l=5.7$, $Mu_h=1.4$, $f_0=2.5$, $dc/f_0=0.22$, relative resistivity 3.75



S-parameters of test structures

- Nickel: resistivity $6.46e-8$ Ohm*meter, Landau-Lifshits Permeability Model: $\mu_l=5.7$, $\mu_h=1.4$, $f_0=2.5$, $dc/f_0=0.22$



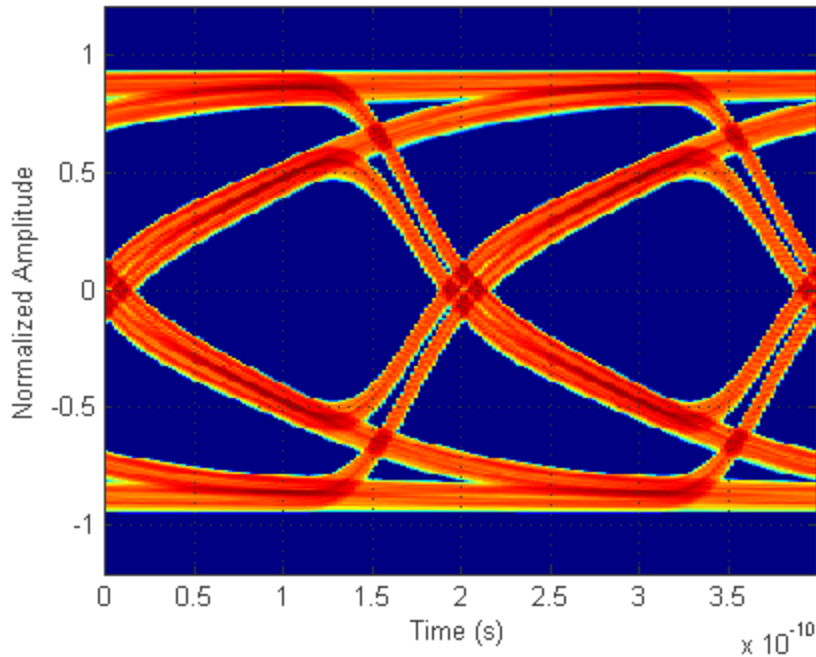
Measured – solid lines
Modeled – stars and circles

5 Gbps signal in structure with 150 mm line



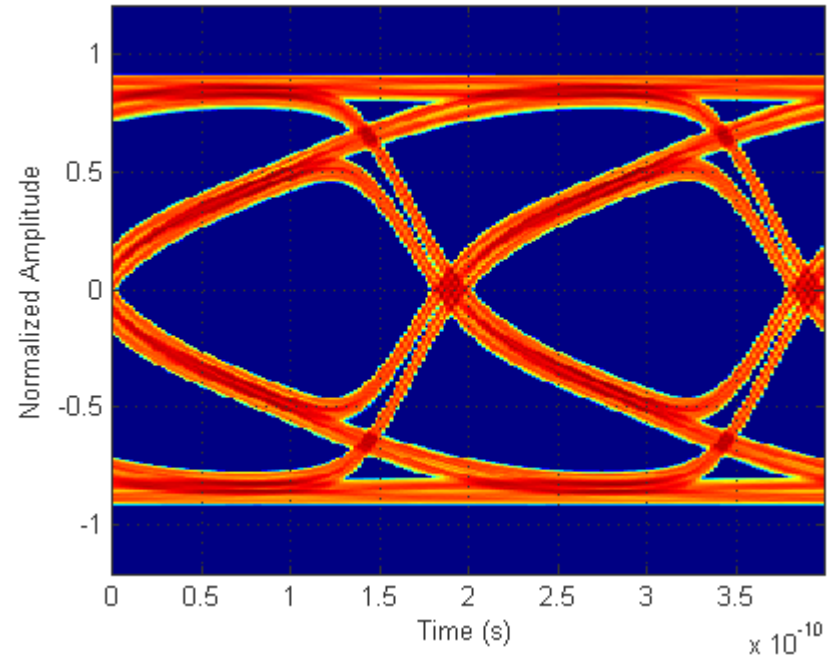
Measured

In-phase Signal



Modeled

In-phase Signal

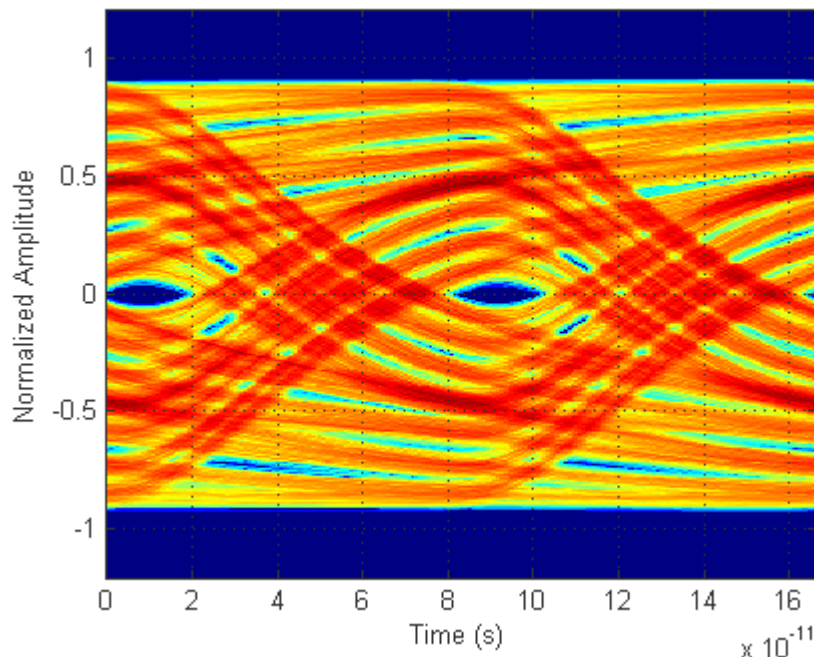


12 Gbps signal in structure with 150 mm line



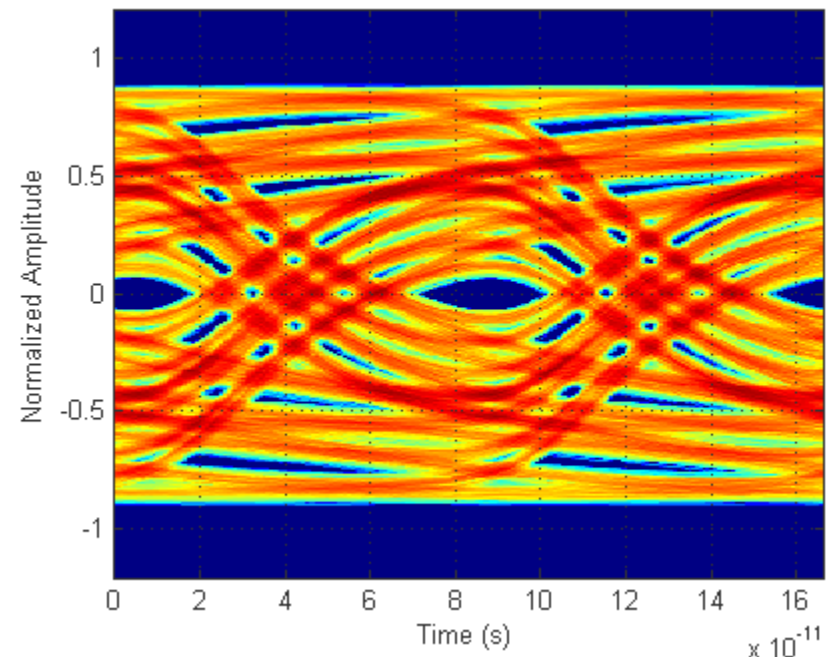
Measured

In-phase Signal



Modeled

In-phase Signal



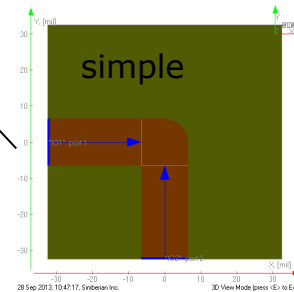
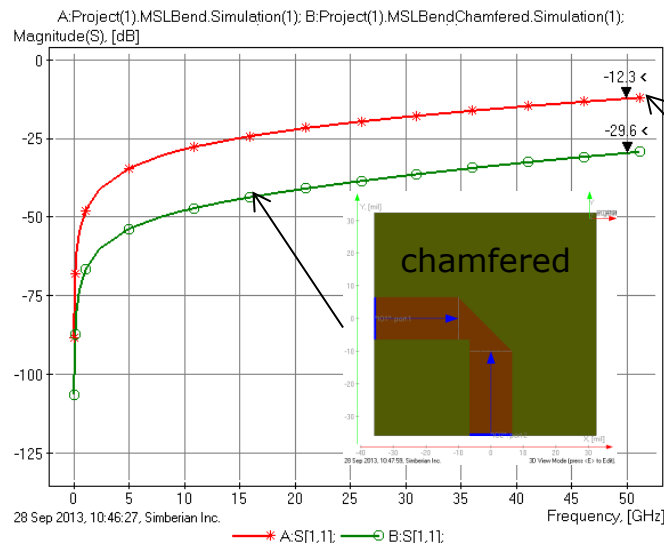
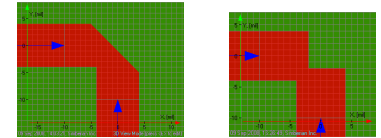
See more in Y. Shlepnev, S. McMorrow, Nickel characterization for interconnect analysis. - Proc. of the 2011 IEEE International Symposium on Electromagnetic Compatibility, Long Beach, CA, USA, August, 2011, p. 524-529. (also available at www.simberian.com)

Summary on material models

- ❑ Provided example illustrates typical situation and importance of the dielectric and conductor models identification
- ❑ Proper separation of loss and dispersion effects between dielectric and conductor models is very important, but not easy task
 - Without proper roughness model, dielectric models is dependent on strip width
 - If strip width is changed, difference in insertion loss predicted by different models may have up to 20-30% for low-loss dielectrics
 - See examples for Panasonic Megtron 6 and Nelco 4000 EP at “Which one is better?...” presentation and “Elements of decompositional analysis...” tutorial from DesignCon 2013 (available at www.simberian.com)
- ❑ In addition, PCB materials are composed of glass fiber and resin and have layered structure
 - Anisotropy: difference between the vertical and horizontal components of the effective dielectric constant
 - Weave effect: resonances and skew
 - All that properties can be modelled in Simbeor software

Planar transitions: Bends

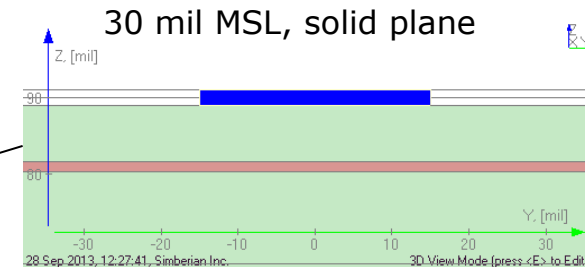
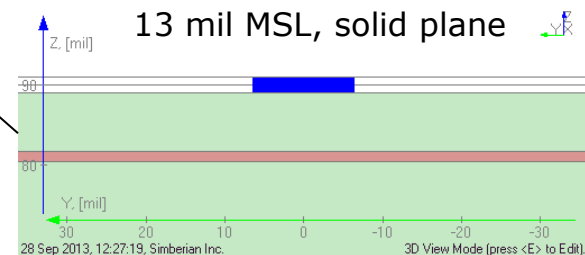
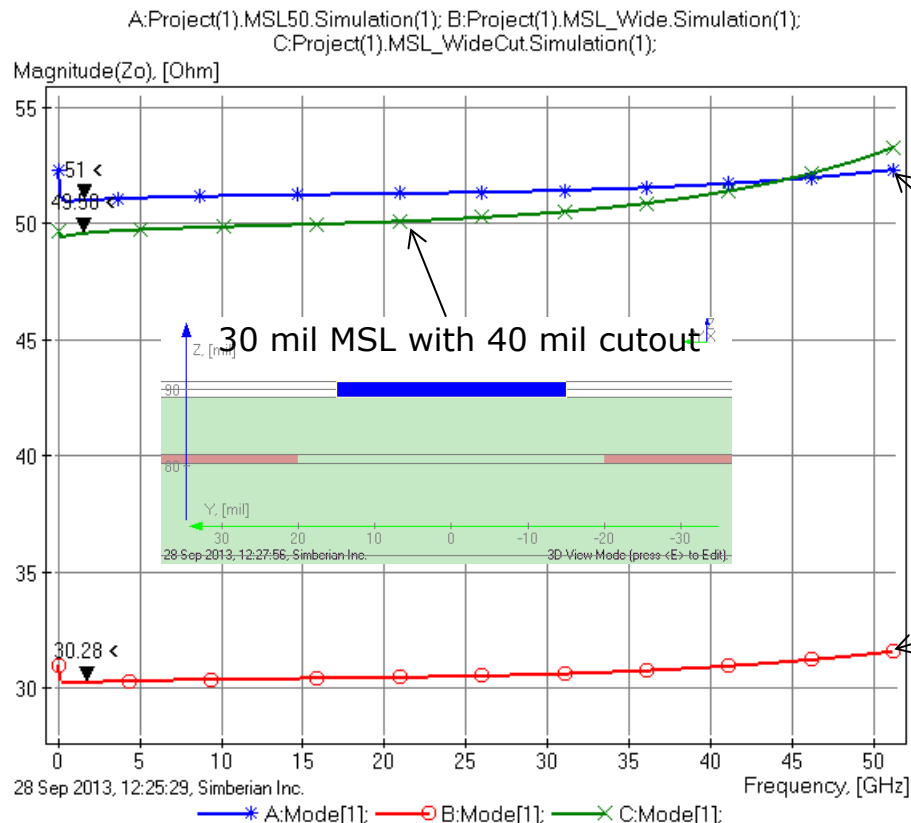
- Design goal is to minimize the reflection loss $|S_{ii}|$
- Have additional capacitance and inductance, uncertainty in trace length
- It is difficult to make them as bad as some other discontinuities
- Potentially multiple bends may cause problems
- Remove of excessive metallization helps to reduce the risks
- See more in App Note #2008_05 at <http://www.simberian.com/AppNotes.php>



Bend in 50-Ohm MSL (13 mil wide in CMP-28 stackup)

Planar transitions to wider strips or pads

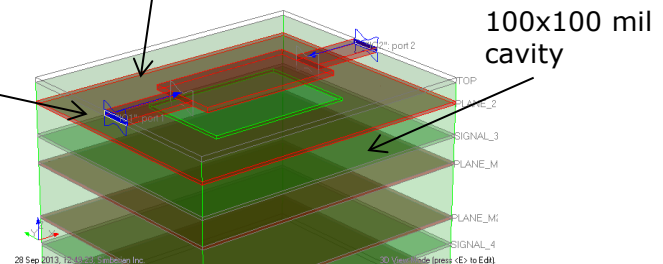
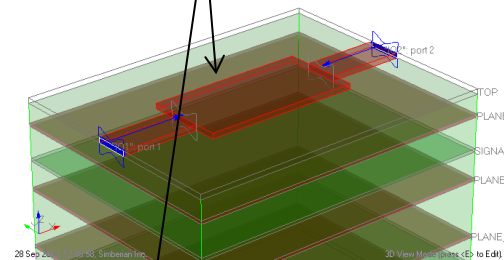
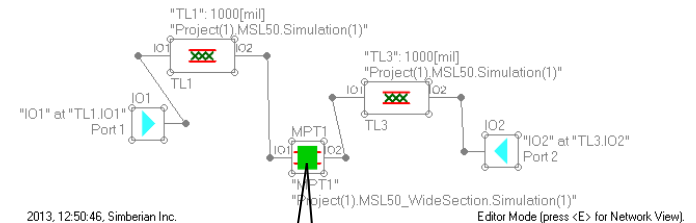
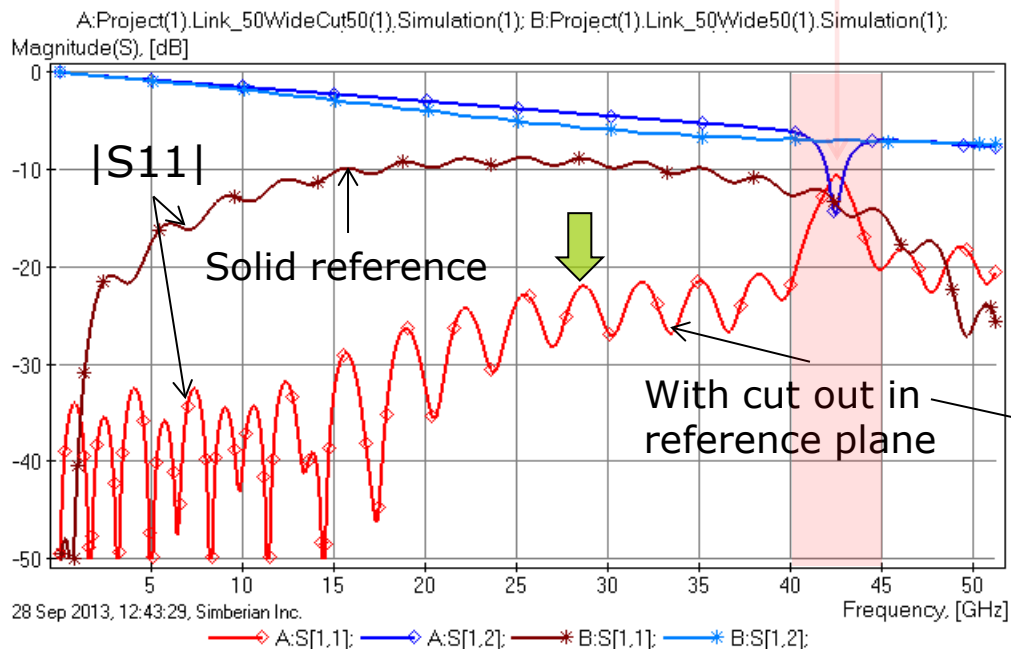
- Optimize to have **target characteristic impedance at wider section**
- Example of transition from 13 mil (~50 Ohm) to 30 mil wide microstrip
 - Create 30 mil wide 50 Ohm transmission line:



Transition to wide strip 3D analysis

- Transition from 13 mil MSL to 60 mil long section of 30 mil wide MSL, CMP-28 stackup

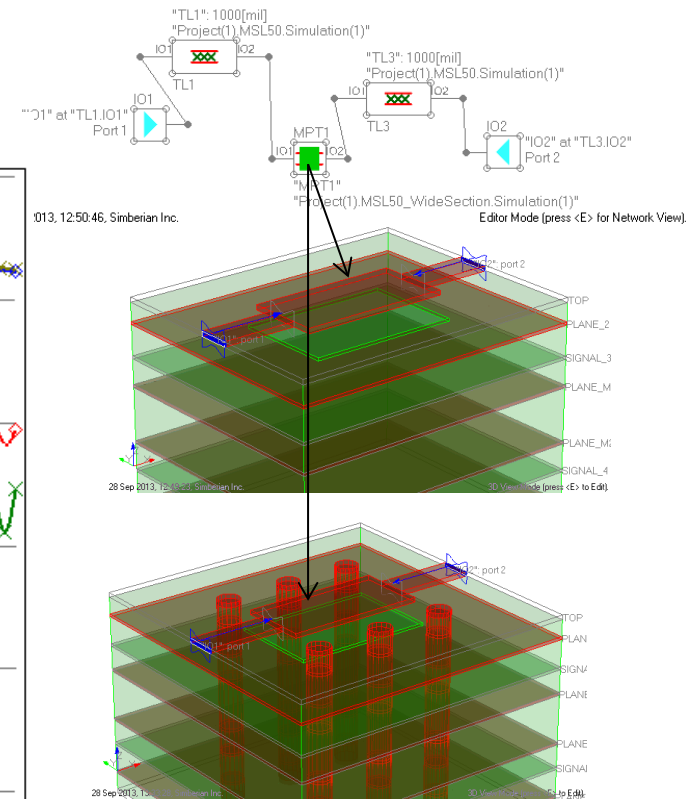
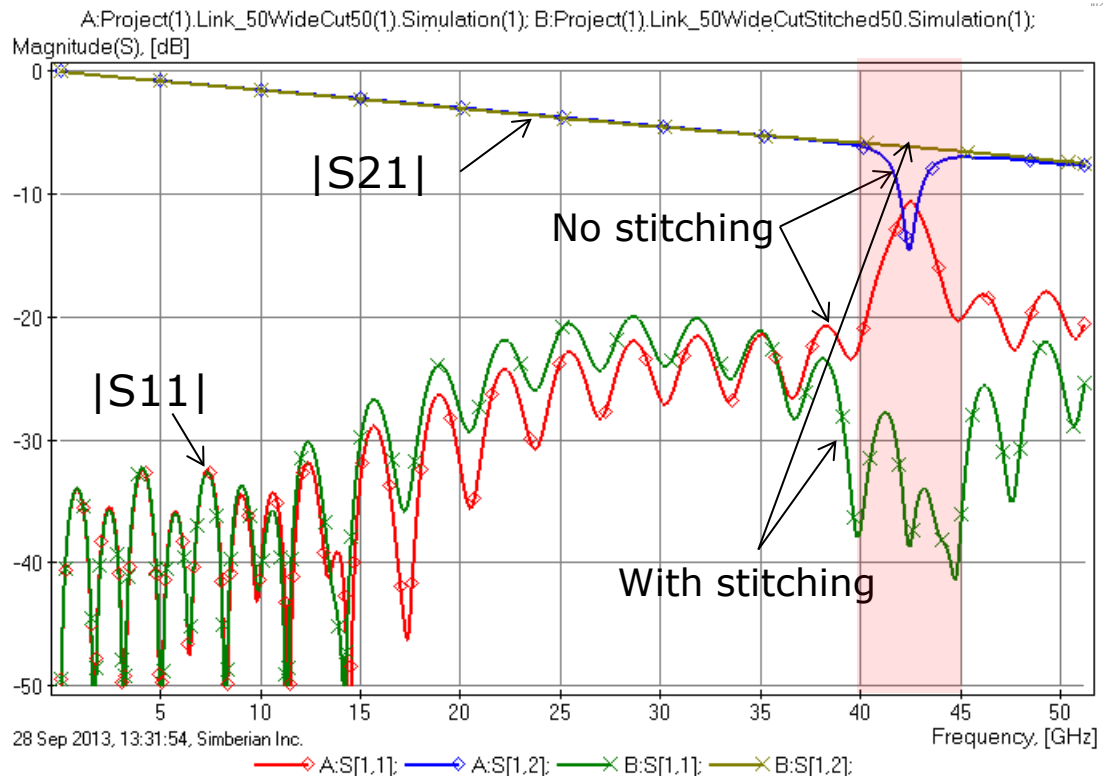
Resonance of cavity below cut-out



Cut-out reduced the reflection as expected, but may create another problem – possible coupling to the cavity below (SI and EMI); **How to deal with that?**

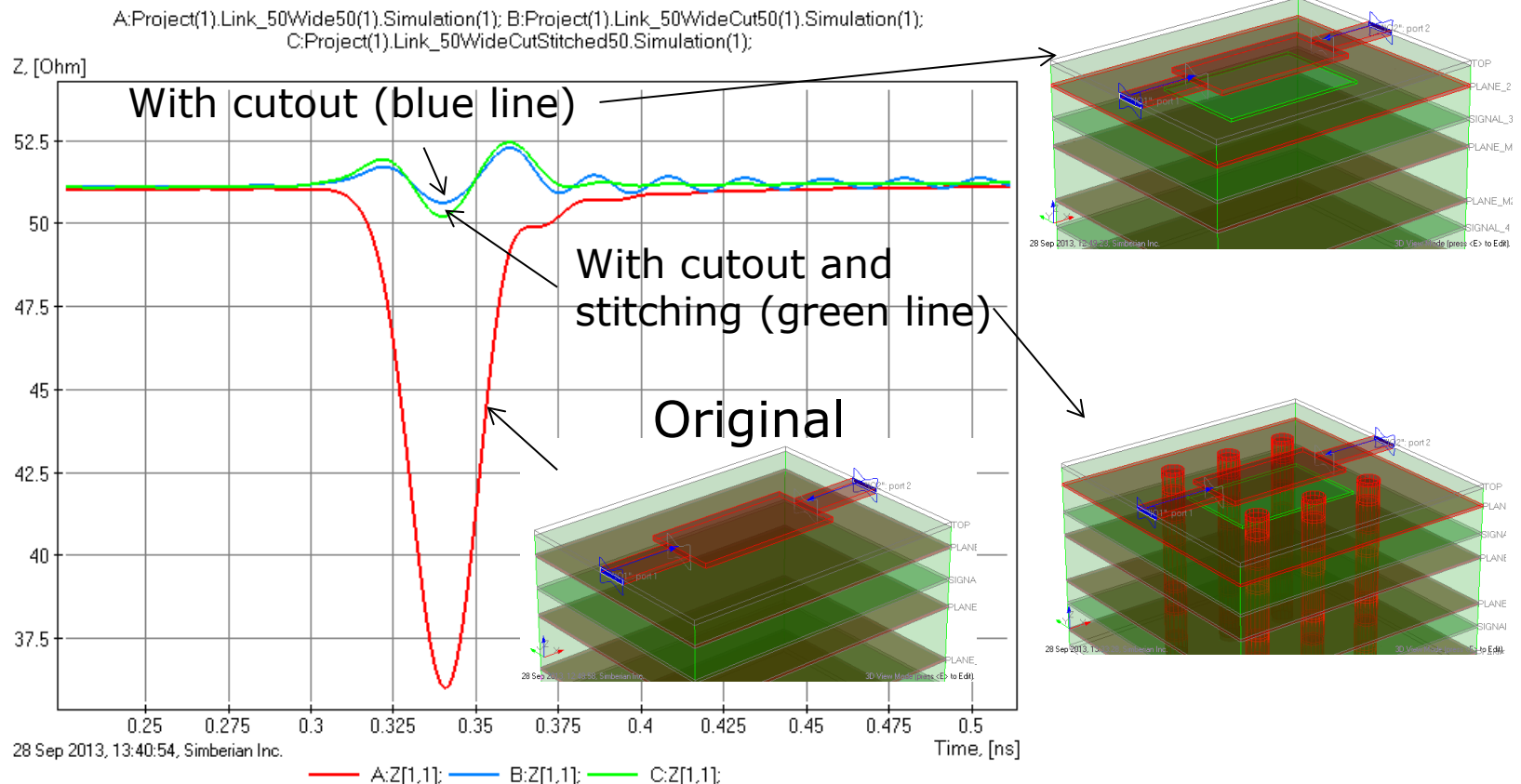
Localizing the cavity below the cut-out

- 6 vias 30 mil apart, stitching the reference plane with the next plane



Transition to wider strip: TDR

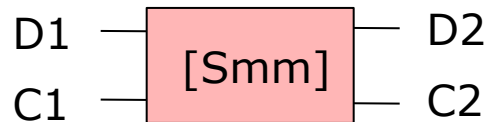
16 ps Gaussian step, 1 inch of 50-Ohm MSL on each side



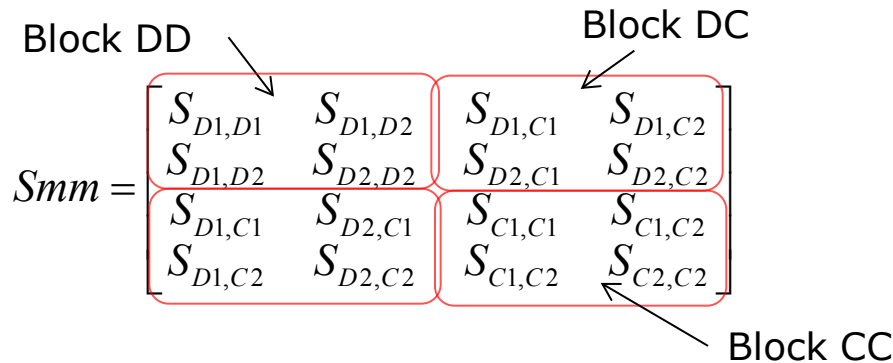
See more on optimization of transitions for AC coupling caps in App Notes #2008_02 and 2008_04 at <http://www.simberian.com/AppNotes.php>

Differential transitions

Transitions Design Goals:
 Minimize $S[D1,D1]$, NEMT, FEMT
 Maximize $|S[D1,D2]|$ and make GD flat



Notation used here (reciprocal):



Alternative forms:

$$S_{mm} = \begin{bmatrix} S_{DD11} & S_{DD12} & S_{DC11} & S_{DC12} \\ S_{DD12} & S_{DD22} & S_{DC21} & S_{DC22} \\ S_{DC11} & S_{DC21} & S_{CC11} & S_{CC12} \\ S_{DC12} & S_{DC22} & S_{CC12} & S_{CC22} \end{bmatrix}$$

$S[D1,D1]$ and $S[D1,D2]$ – **differential mode reflection and transmission**

$S[D1,C1]$, $S[D2,C2]$ – **near end mode transformation (NEMT)** or transformation from differential to common mode at the same side of the multiport

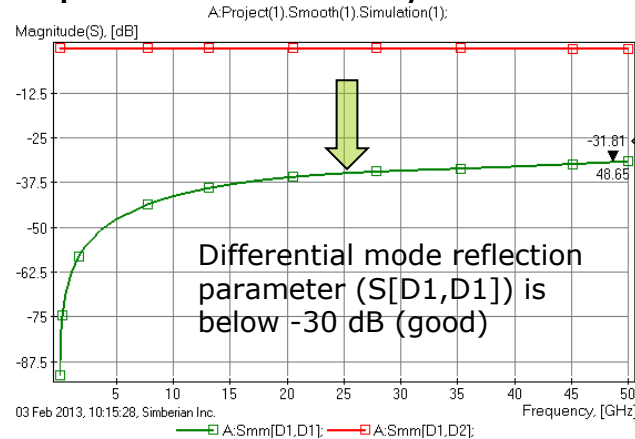
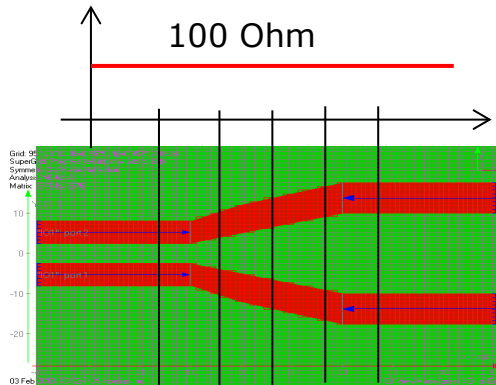
$S[D1,C2]$, $S[D2,C1]$ – **far end mode transformation (FEMT)** or transformation from differential mode on one side to the common mode on the opposite side of the multiport

$$S_{mm} = \begin{bmatrix} S_{1,1}^{dd} & S_{1,2}^{dd} & S_{1,1}^{dc} & S_{1,2}^{dc} \\ S_{1,2}^{dd} & S_{2,2}^{dd} & S_{2,1}^{dc} & S_{2,2}^{dc} \\ S_{1,1}^{dc} & S_{2,1}^{dc} & S_{1,1}^{cc} & S_{1,2}^{cc} \\ S_{1,2}^{dc} & S_{2,2}^{dc} & S_{1,2}^{cc} & S_{2,2}^{cc} \end{bmatrix}$$

See more on definitions in
 Simberian App Note #2009_01

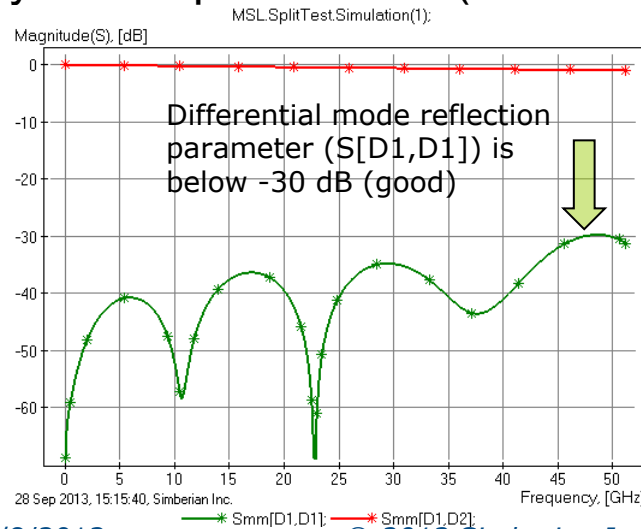
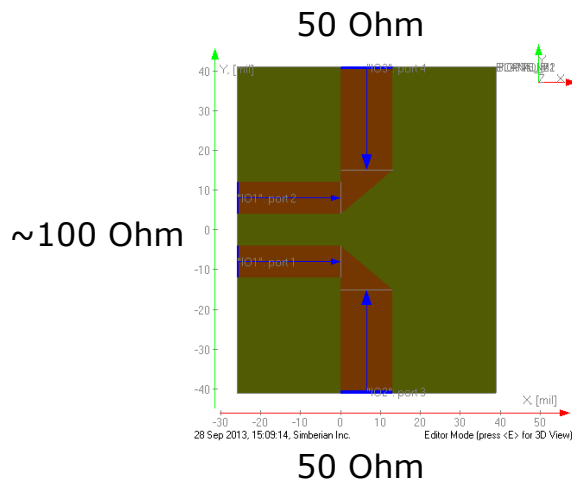
Transitions from differential to single

- Maintain the target differential impedance in every cross-section



See more on transitions in App Note #2013_04

- Or minimize the discontinuity in abrupt transition (similar to single bend)

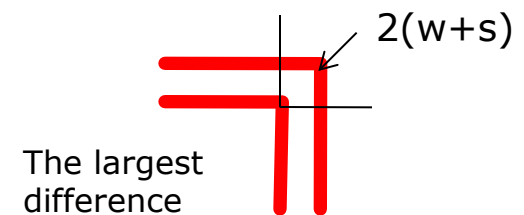
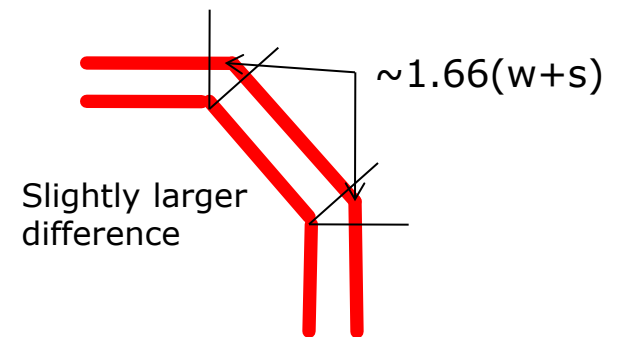
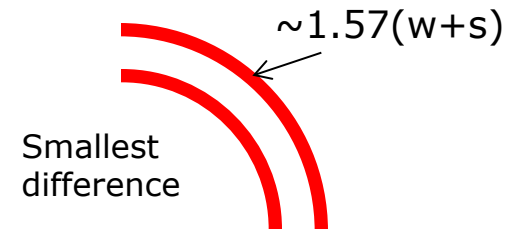


CMP-28 stackup, also used in skew analysis

100 mil diff MSL + split + 2 100 mil SE MSL + split + 100 mil diff MSL

Differential bends: Qualitative analysis

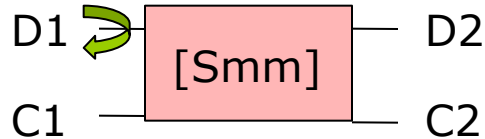
- Skew or mode transformation in bends is usually attributed to differences in lengths of the traces
 - That is how it is usually modeled in traditional SI software that uses static field solvers to extract t-line parameters and ignore the discontinuities like bends
- According to that measure the arched bend is better than two 45-degree and two 45-degree bend is better than 90-degree bend
- **Is this correct statement?**
 - Investigation is provided in App Note #2009_02 and here are some results...



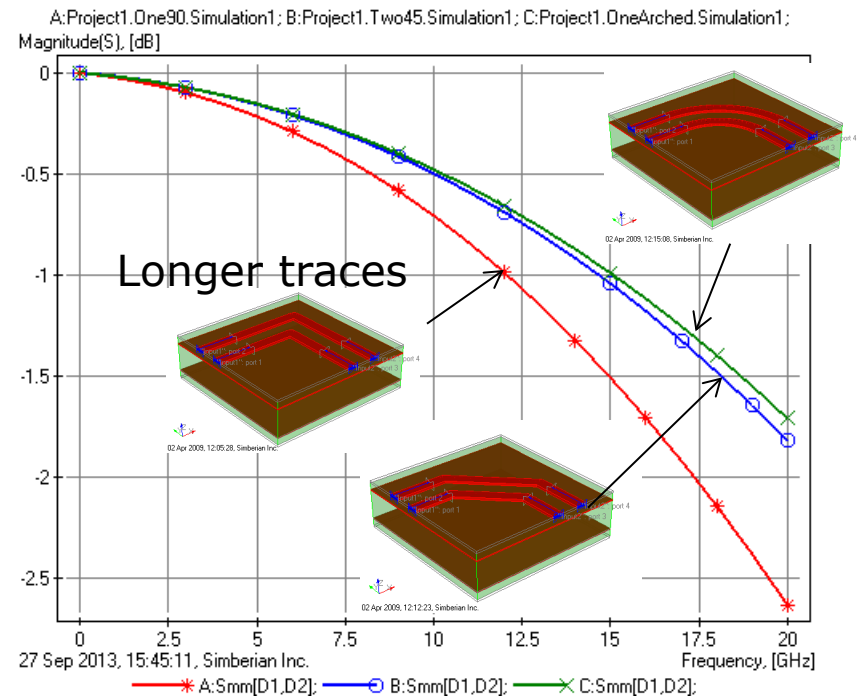
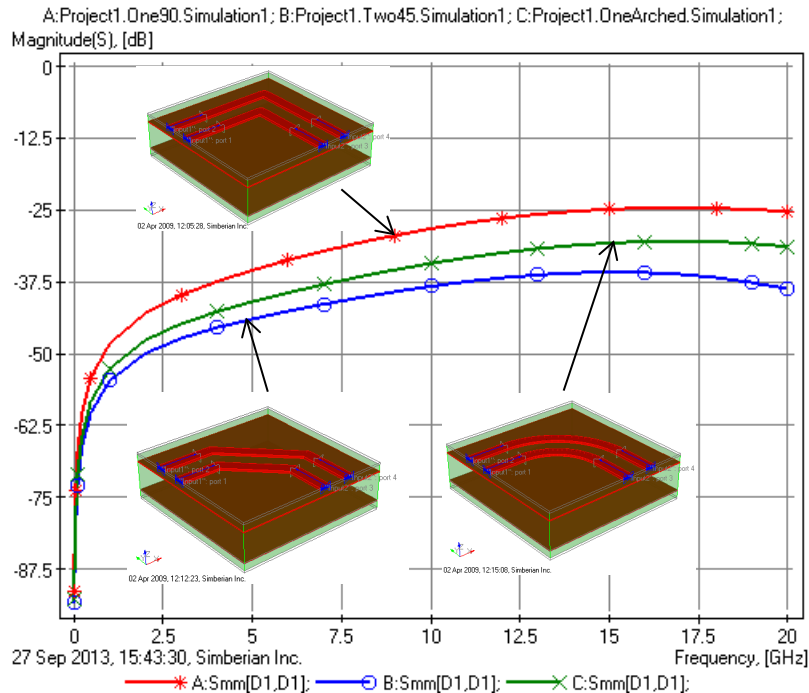
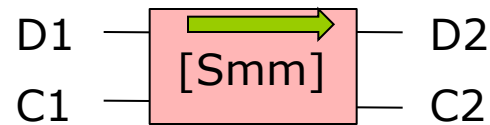
w is strip width and s is separation

Differential reflection and transmission

Differential reflection S[D1,D1]



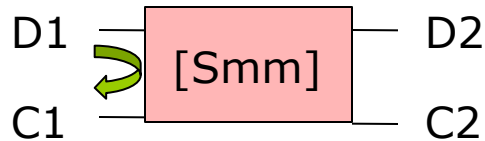
Differential transmission S[D2,D1]



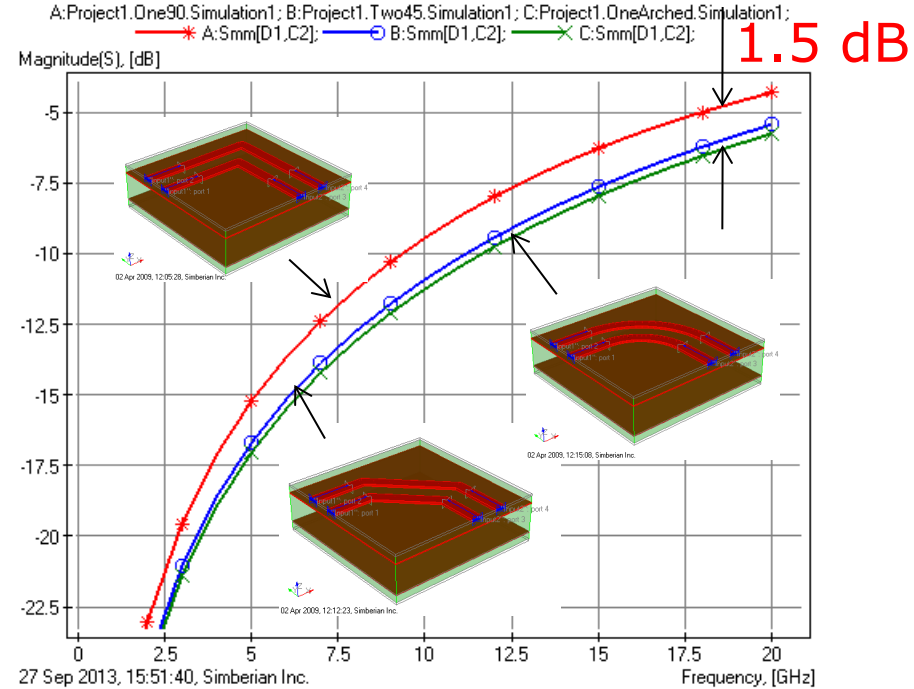
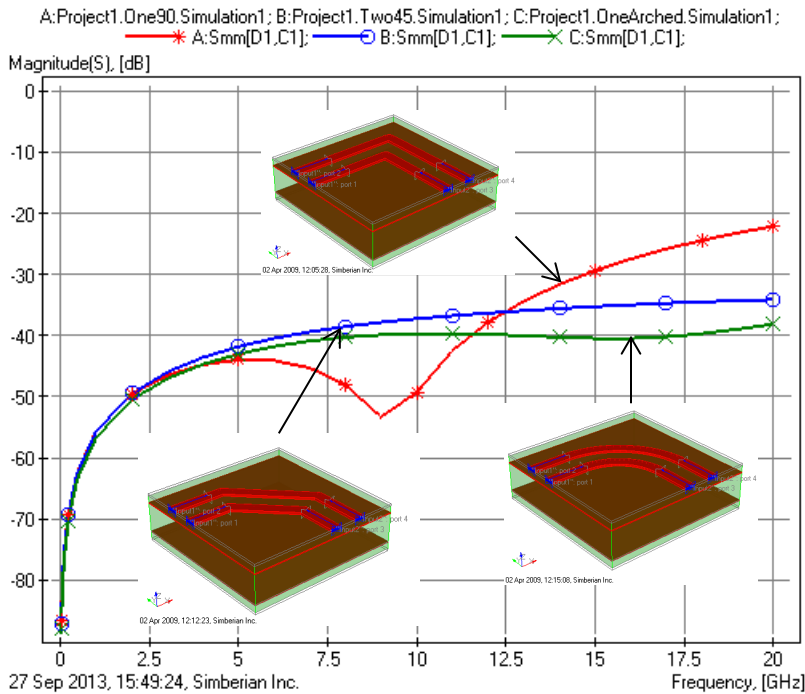
No difference for practical applications!

Mode transformation (skew and EMI)

NEMT S[D1,C1]



FEMT S[D1,C2]



More modal transformations at 90-degree bend!

Practical example of skew analysis for nets with microstrip (MSL) arched bends

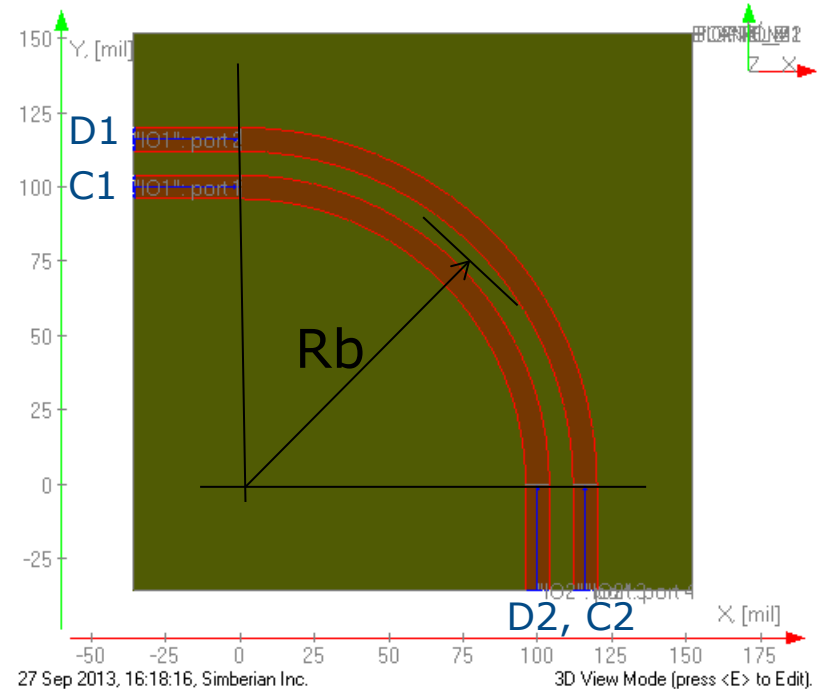
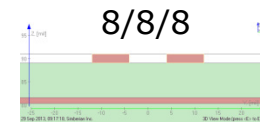
- 8-layer stackup from CMP-28 benchmark board from Wild River Technology, <http://wildrivertech.com>
- Material models are identified with GMS-parameters
- Two 8 mil strips 8 mil apart in layer TOP (microstrip)

Materials: T=20[°C],...

- "1OZ_COPPER", RR=1, SR=0.32, RF=3.3, RM=Original
- "PLATED_1OZ_COPPER", RR=1, SR=0.32, RF=3.3, RM=MHCC
- "FR-408HR", Dk=3.83, LT=0.0117, PLM=WD, Dk(0)=4.29, Dk(inf)=3.63
- "Air"
- "Soldermask", Dk=3.7, LT=0.02, PLM=WD, Dk(0)=4.46, Dk(inf)=3.37

StackUp: LU=[mil], NL=8, T=91[mil], CSM=("Soldermask", 1.75[mil])

- 1 | Signal: "TOP", T=2, Ins="Air", Cond="PLATED_1OZ_COPPER"
- 2 | Medium: T=7.4, Ins="FR-408HR", DIE_003
- 3 | Plane: "PLANE_2", Cond="1OZ_COPPER", T=1.2, Ins="FR-408HR"
- 4 | Medium: T=12, Ins="FR-408HR", DIE_005
- 5 | Signal: "SIGNAL_3", T=1.2, Ins="FR-408HR", Cond="1OZ_COPPER"
- 6 | Medium: T=10, Ins="FR-408HR", DIE_007
- 7 | Plane: "PLANE_M1", Cond="1OZ_COPPER", T=1.2, Ins="FR-408HR"
- 8 | Medium: T=21, Ins="FR-408HR", DIE_008
- 9 | Plane: "PLANE_M2", Cond="1OZ_COPPER", T=1.2, Ins="FR-408HR"
- 10 | Medium: T=10, Ins="FR-408HR", DIE_009
- 11 | Signal: "SIGNAL_4", T=1.2, Ins="FR-408HR", Cond="1OZ_COPPER"
- 12 | Medium: T=12, Ins="FR-408HR", DIE_011
- 13 | Plane: "PLANE_5", Cond="1OZ_COPPER", T=1.2, Ins="FR-408HR"
- 14 | Medium: T=7.4, Ins="FR-408HR", DIE_013
- 15 | Signal: "BOTTOM", T=2, Ins="Air", Cond="PLATED_1OZ_COPPER"

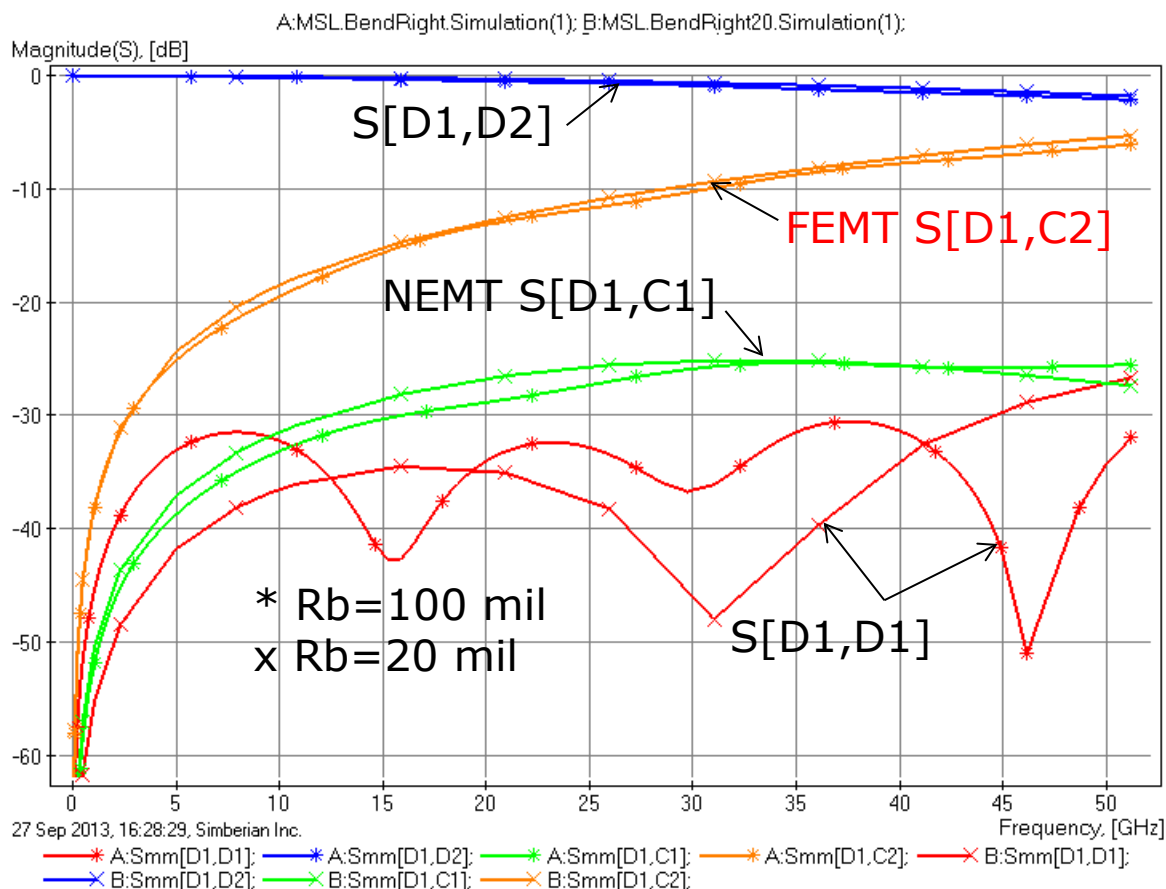


We investigate two bends with $R_b=108$ mil and $R_b=28$ mil (center line)

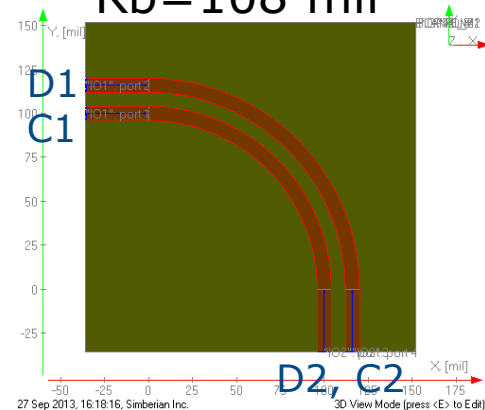
Both bends have identical 25 mil difference in strip lengths

Effect of bend radius

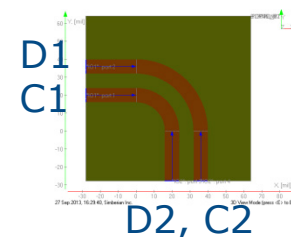
- Very similar modal transformations in larger and smaller bends!



Rb=108 mil



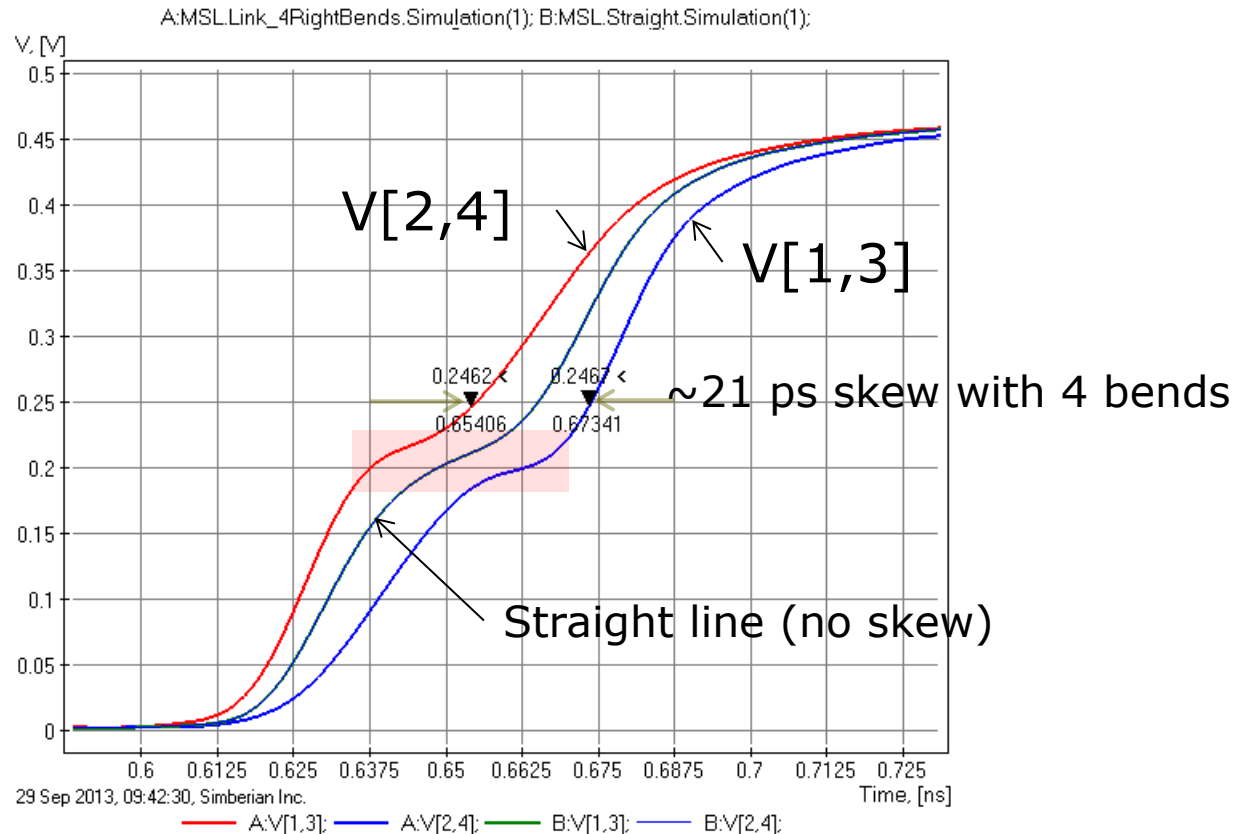
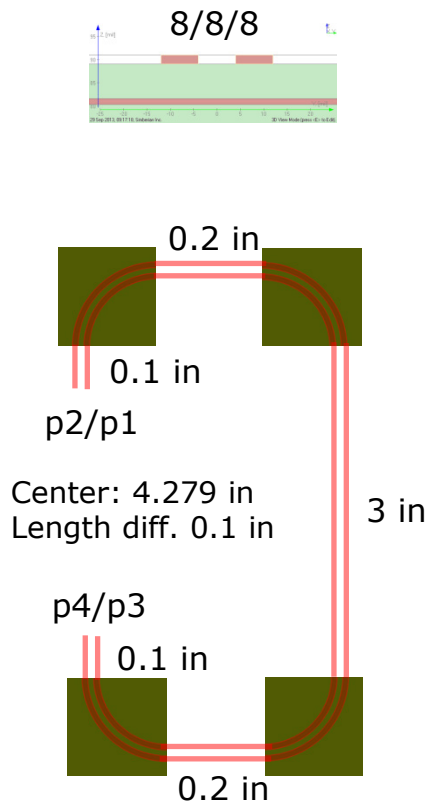
Rb=28 mil



FEMT is definitely a problem (skew, EMI)!

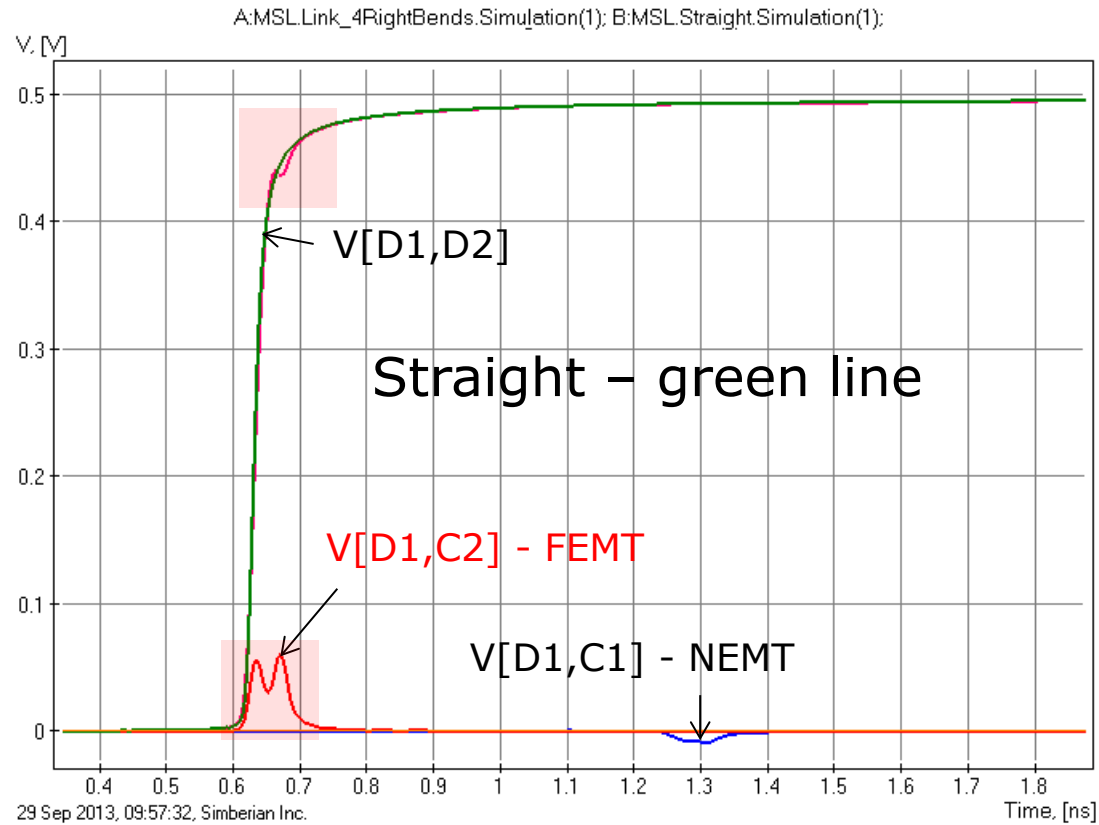
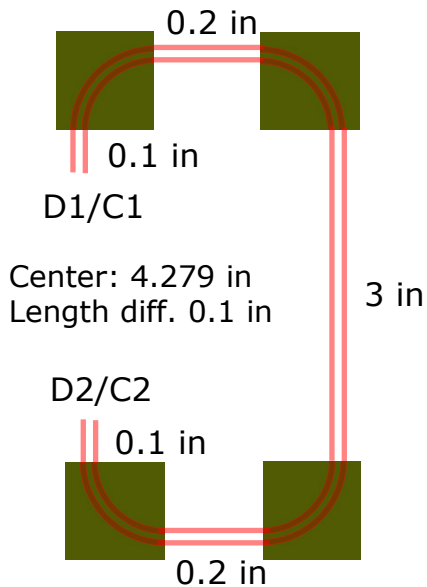
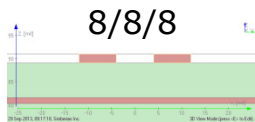
MSL link with 4 right bends – SE TDT

Single-ended TDT, 0.5 V 16 ps Gaussian step



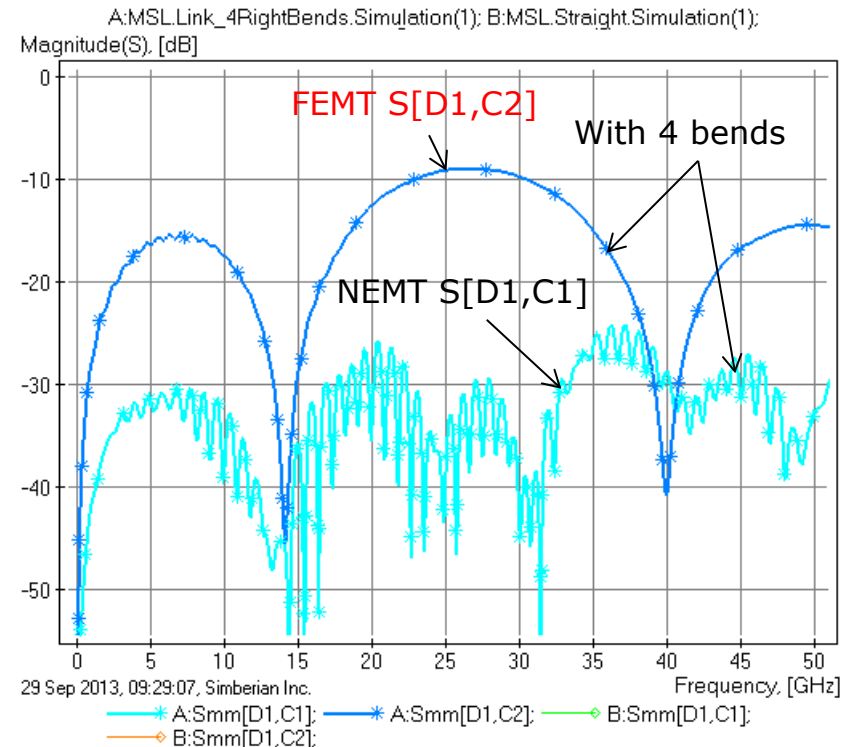
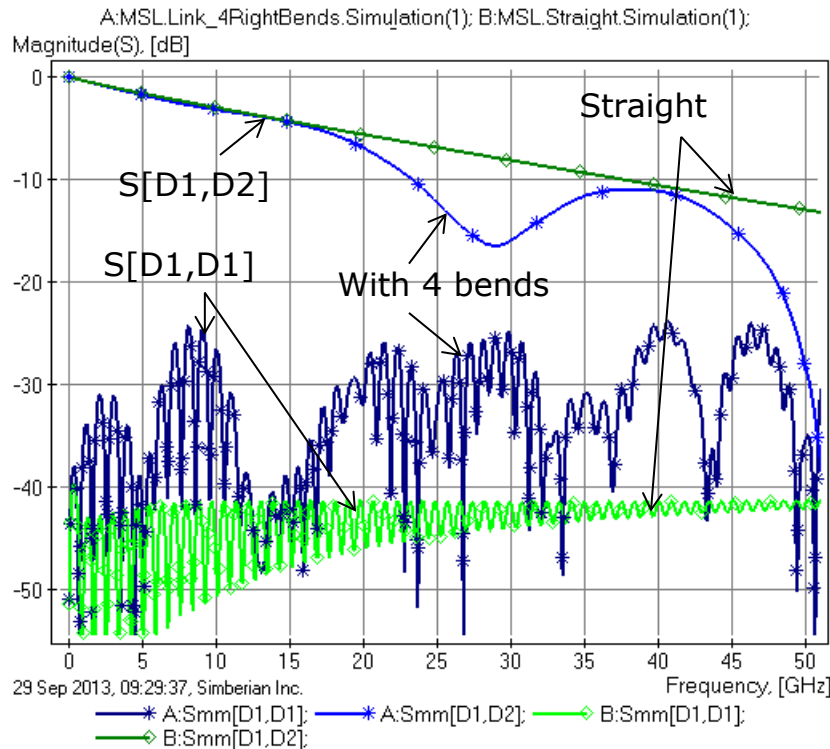
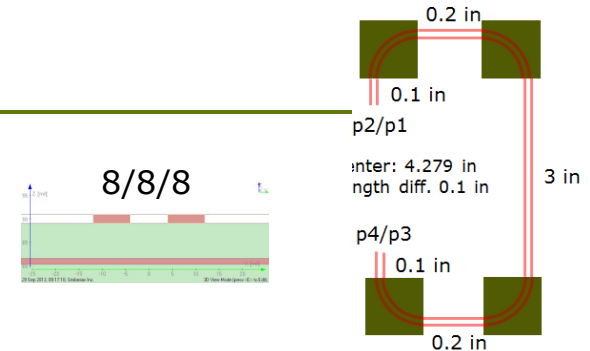
MSL link with 4 right bends – MM TDT

Mixed-mode TDT, 0.5 V 16 ps Gaussian step

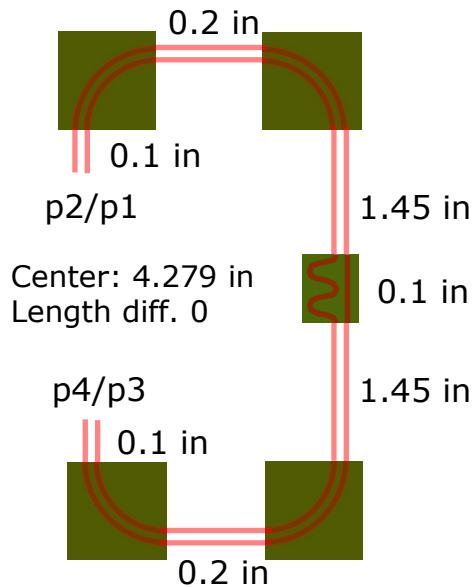
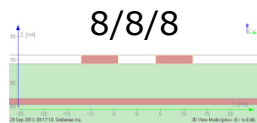


MSL link with 4 right bends: “Skew” view on S-parameters

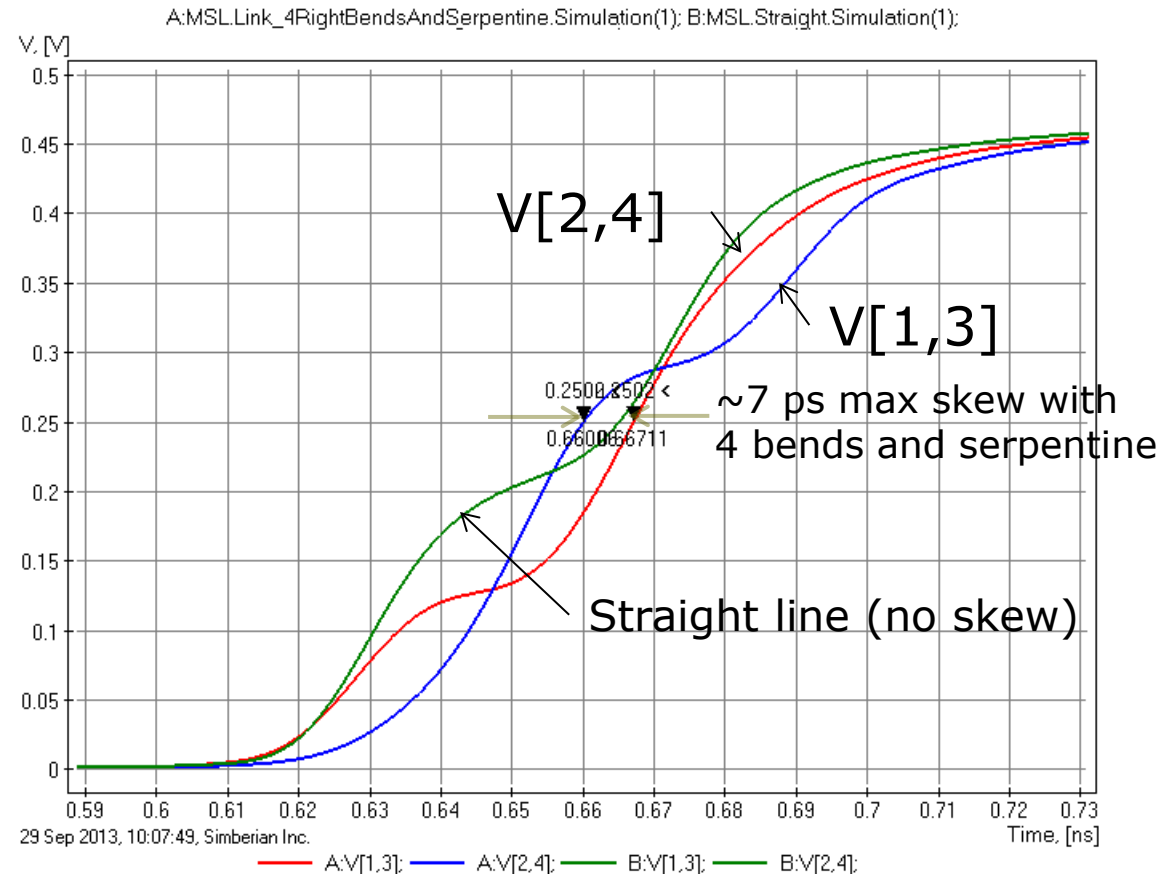
How to fix it? – match length?



MSL link with 4 right bends and serpentine – SE TDT

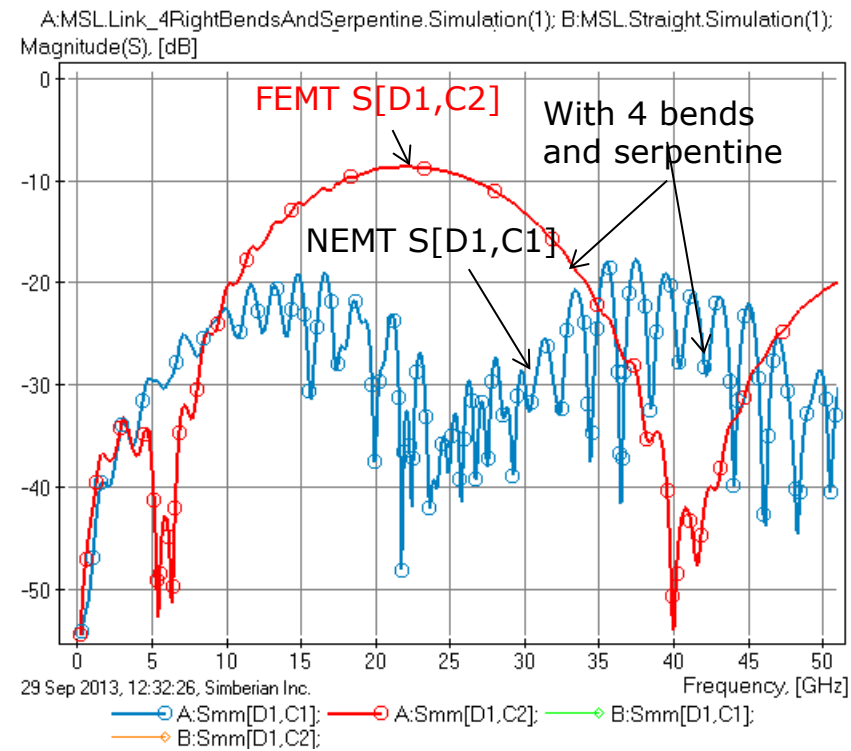
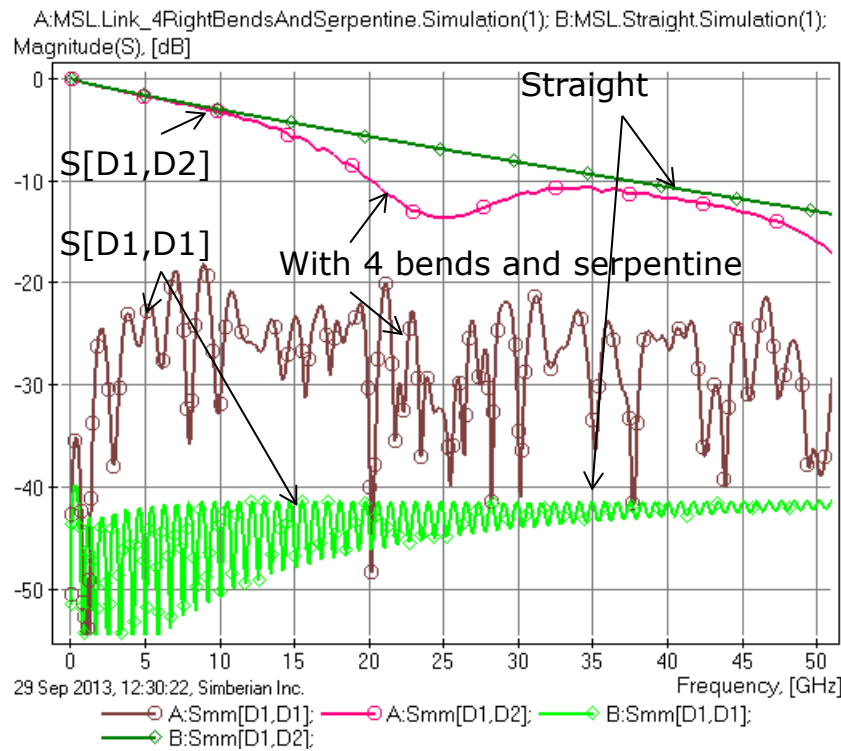
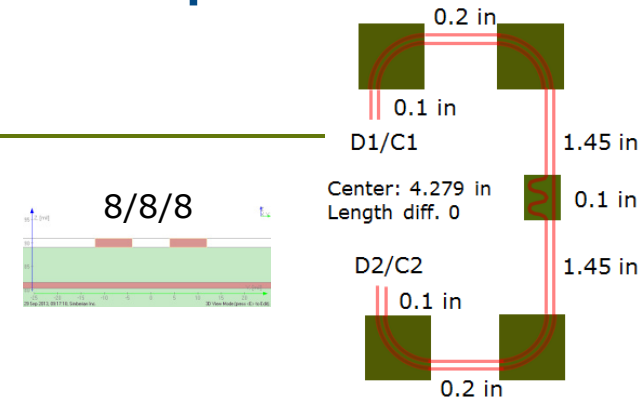


Mixed-mode TDT, 0.5 V 16 ps Gaussian step



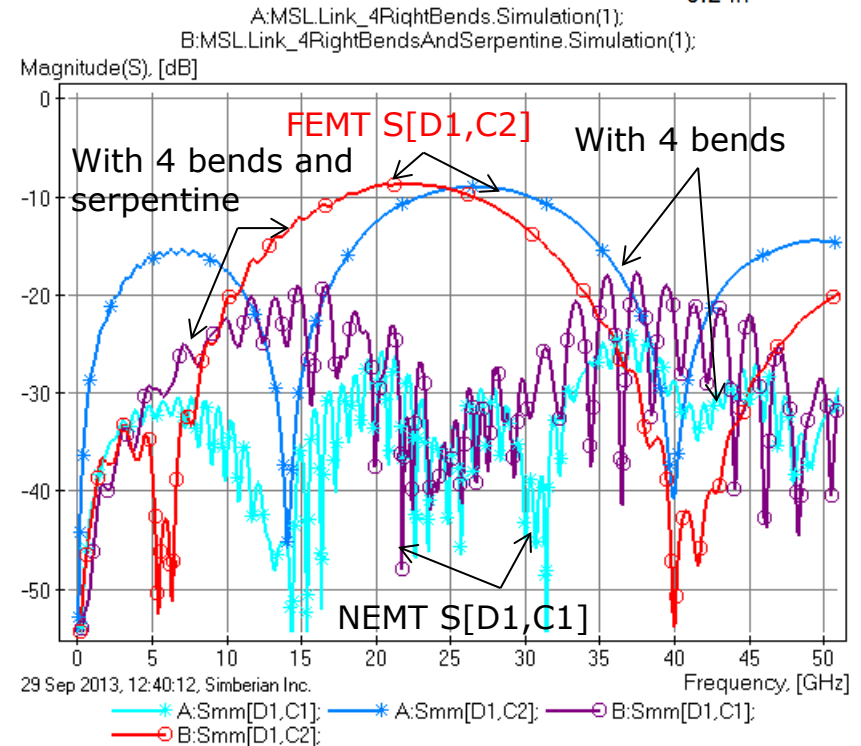
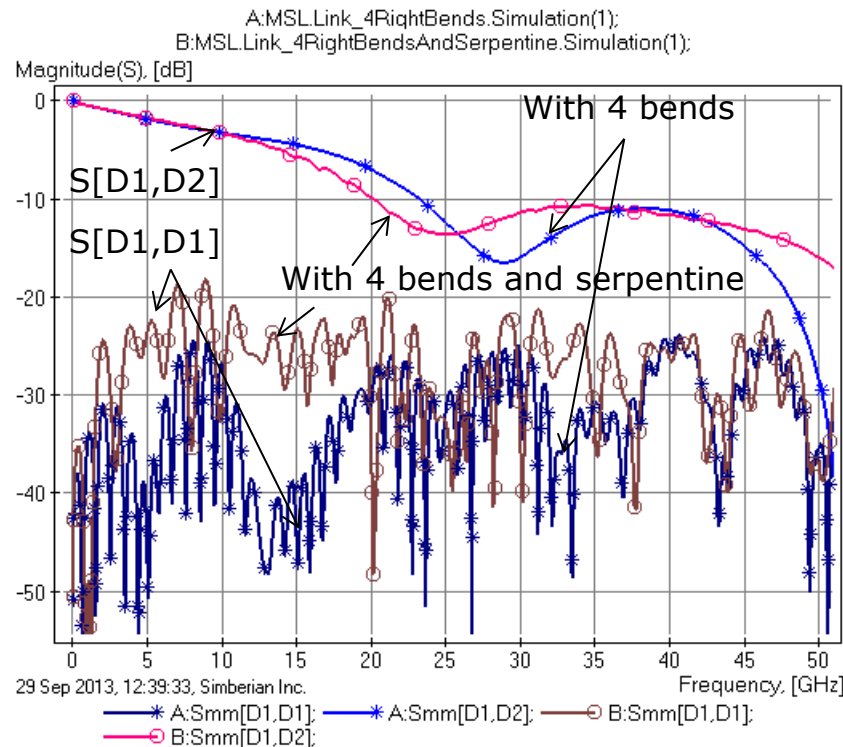
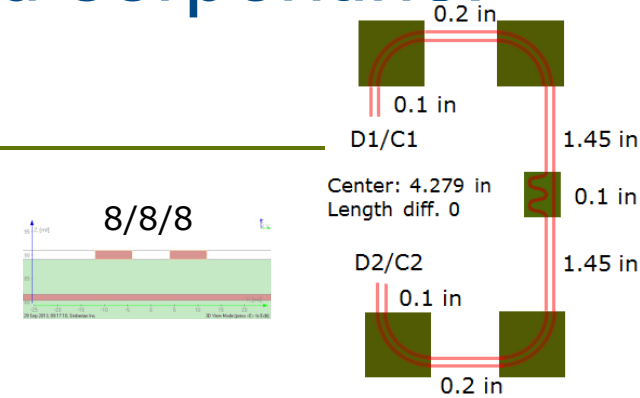
MSL link with 4 right bends and serpentine: "Skew" view on S-parameters

- Length match did not fix the problem!

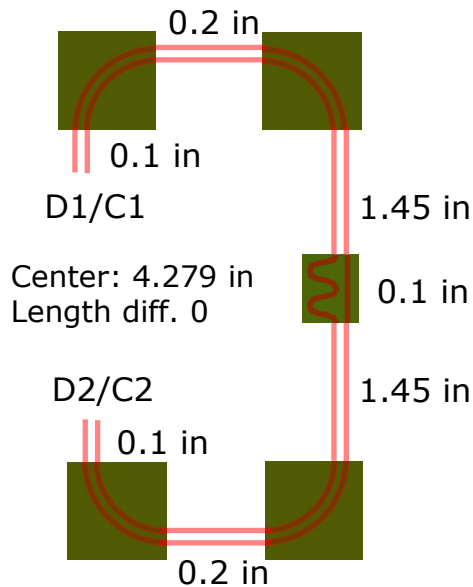
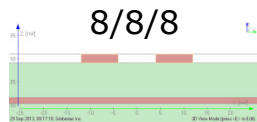


MSL link with 4 right bends and serpentine: “Skew” view on S-parameters

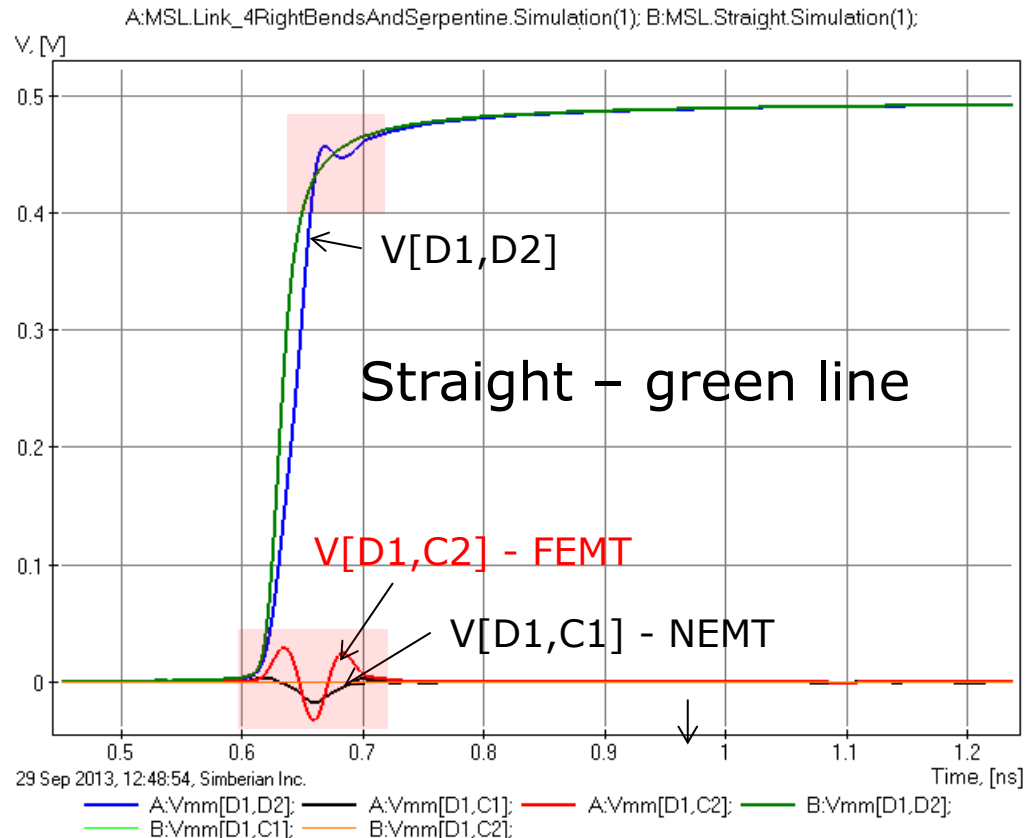
- Actually made it worse:
MT at lower frequencies



MSL link with 4 right bends and serpentine – MM TDT



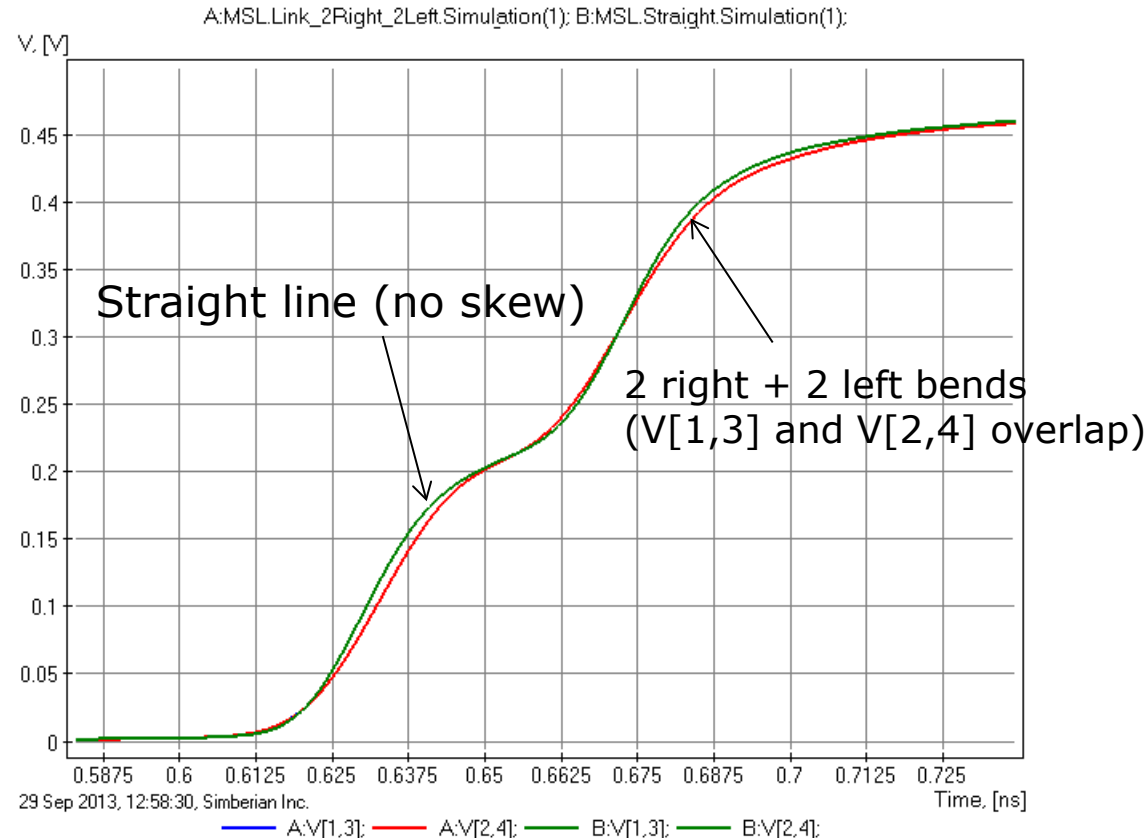
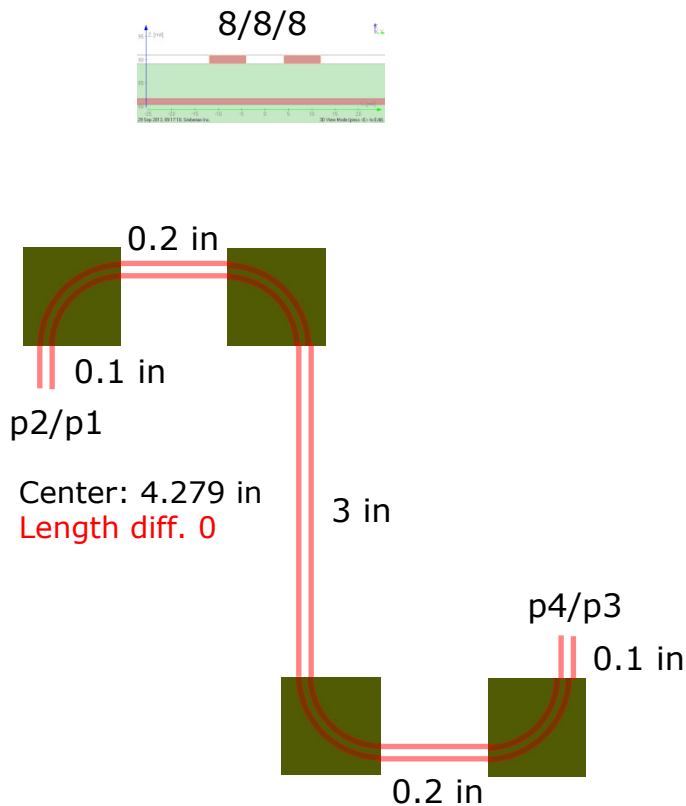
Mixed-mode TDT, 0.5 V 16 ps Gaussian step



Length match in microstrip link clearly did not work!
May be it was not done properly?

MSL link with 2 right and 2 left bends – SE TDT

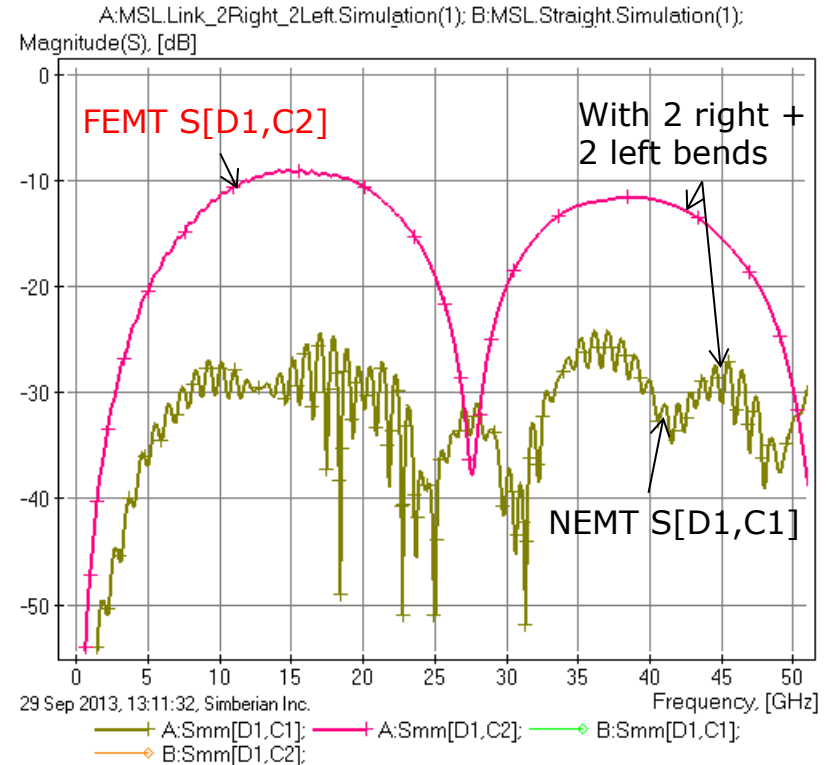
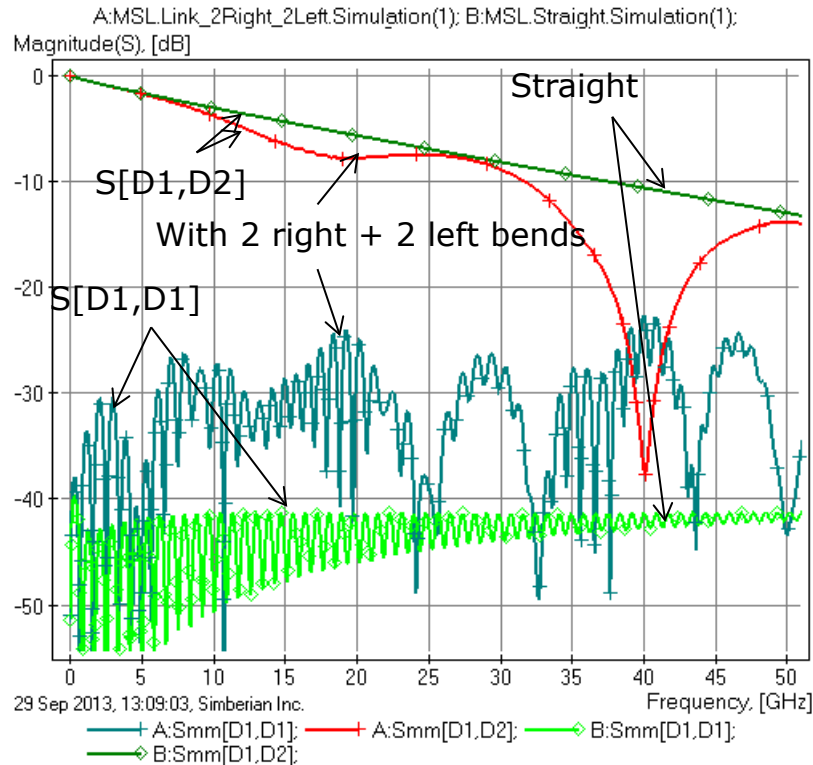
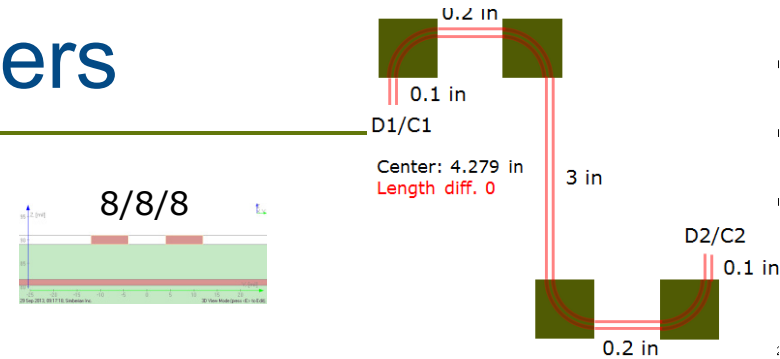
Single-ended TDT, 0.5 V 16 ps Gaussian step



The best we can do, but did it solver the problem?

MSL link with 2 right + 2 left bends: “Skew” view on S-parameters

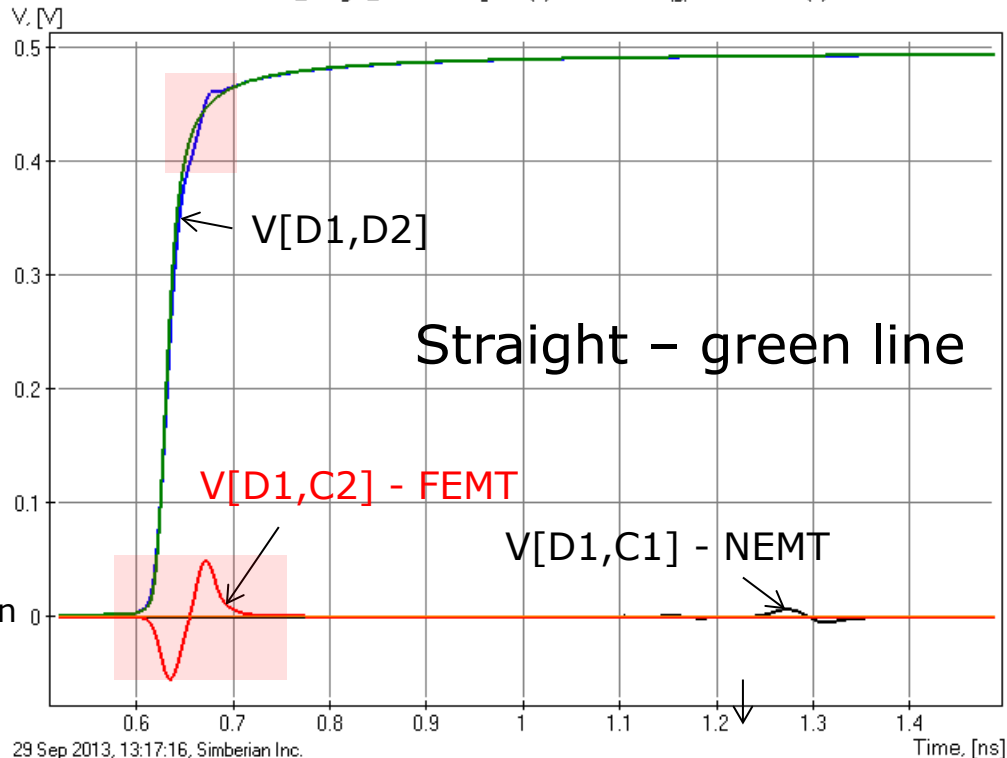
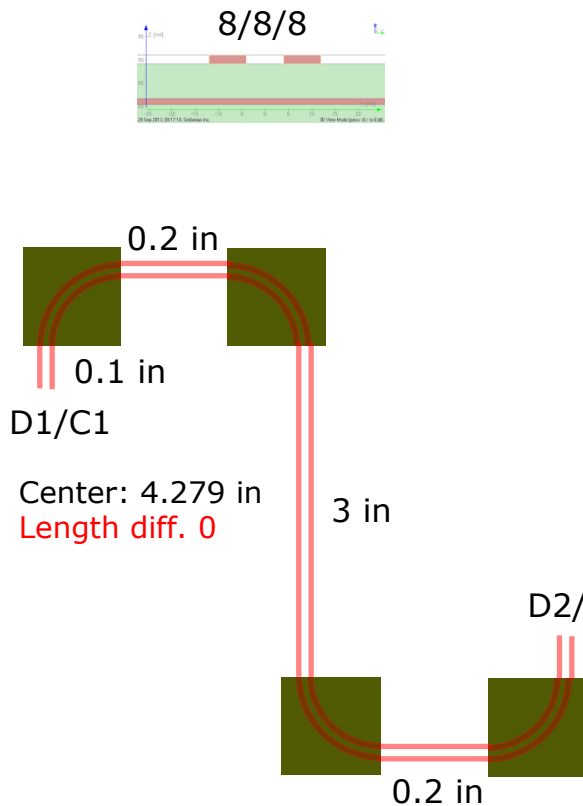
- Still problem with insertion loss and mode transformation!



MSL link with 2 right + 2 left bends and serpentine – MM TDT

Mixed-mode TDT, 0.5 V 16 ps Gaussian step

A:MSLLink_2Right_2Left.Simulation(1); B:MSL.Straight.Simulation(1);

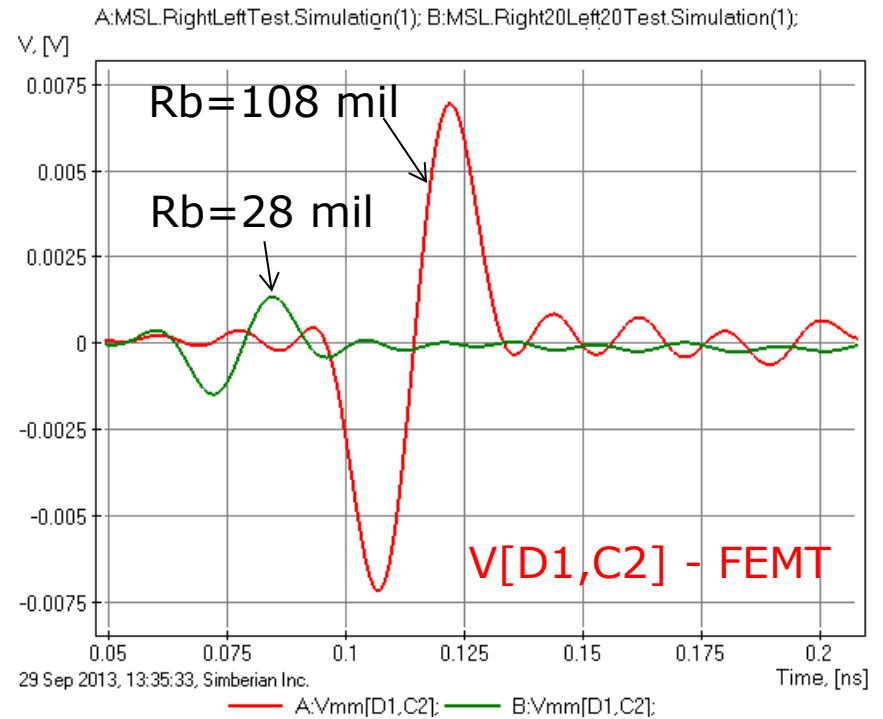
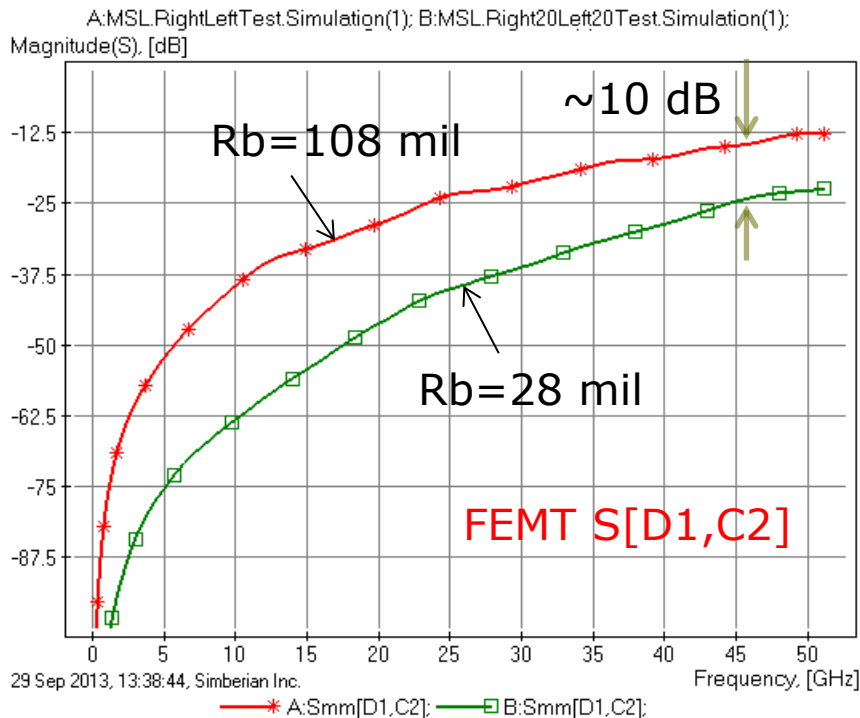


Length match in microstrip link does not work?
Let's try to figure out why...

MSL back-to-back right and left bends

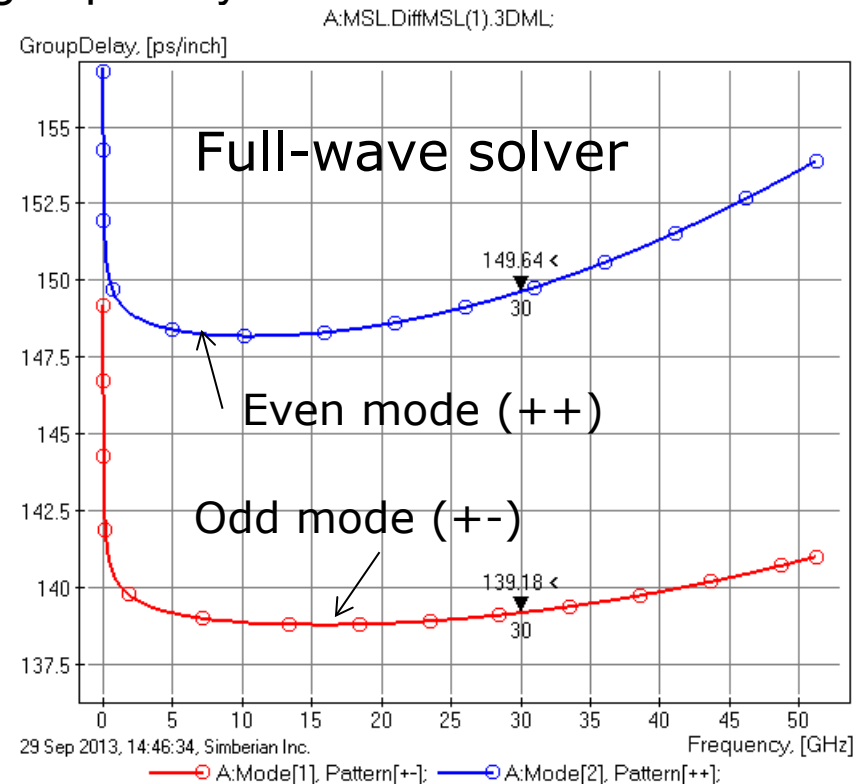
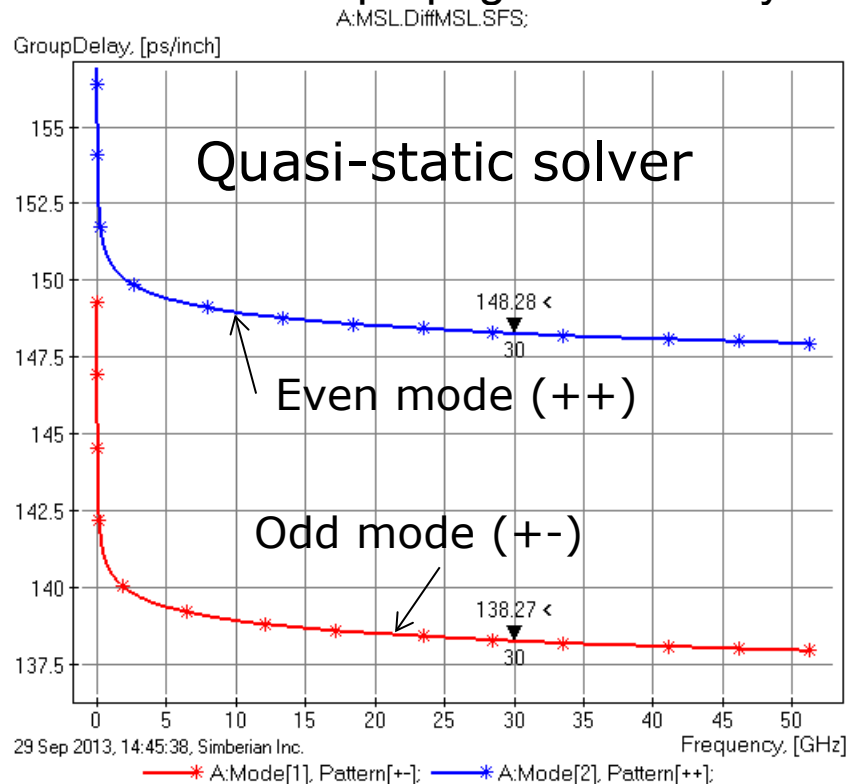


Only small close complimentary bends reduce the mode transformation and skew and EMI!



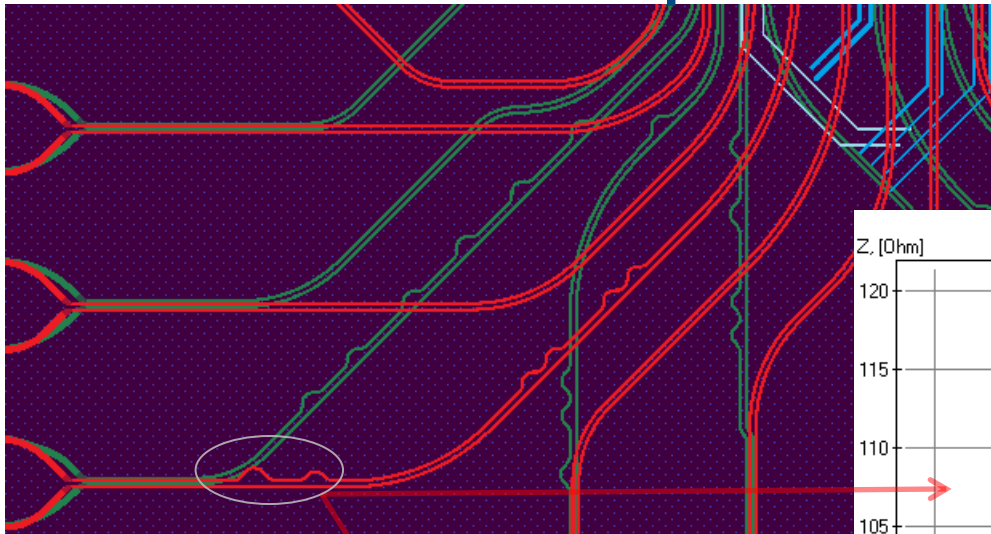
Why length matching does not work for microstrip lines?

- Energy along the coupled MSL propagate in even and odd modes and they have different propagation velocity or group delay:

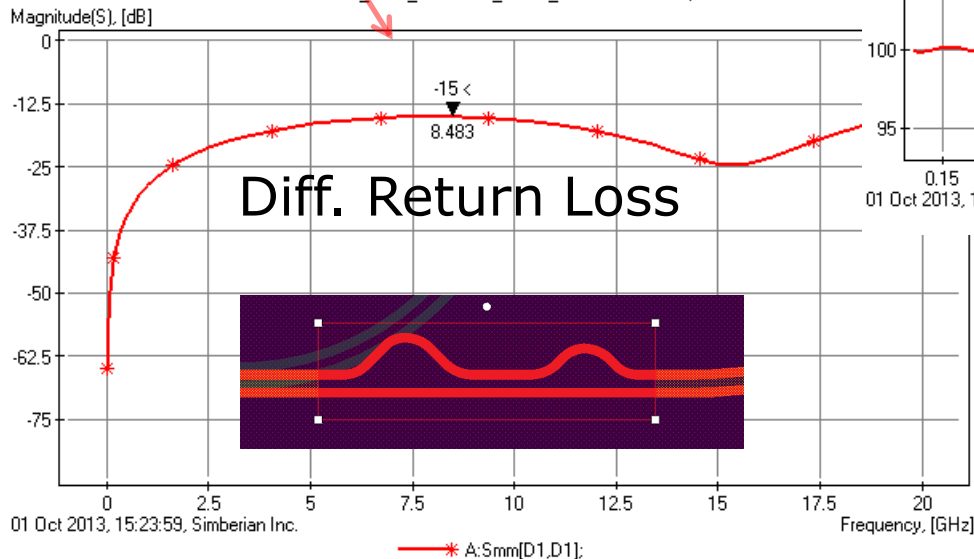
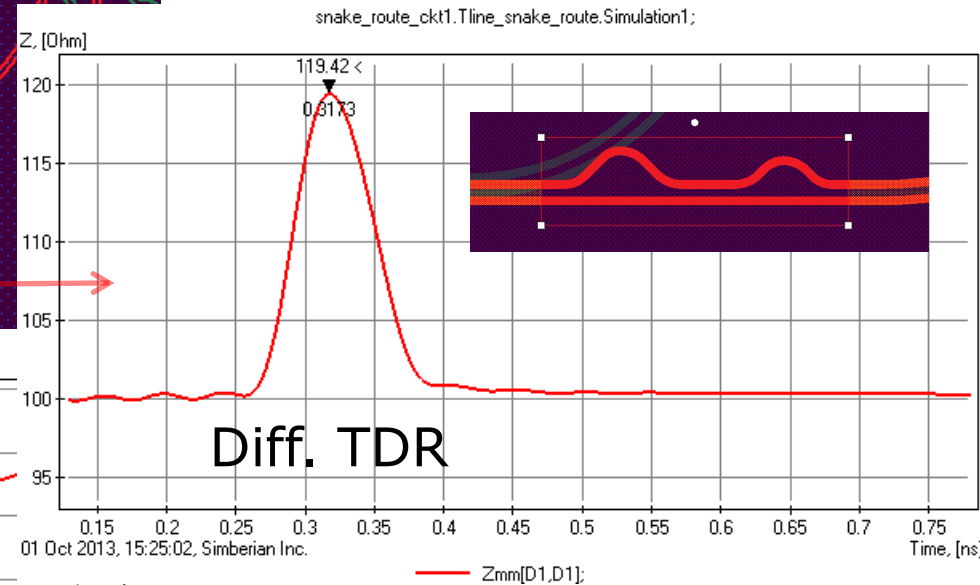


Will length compensation work if no difference in mode velocity (strip lines)? ...
 Depends on how you do it – see Simbeor FRSI examples on skew in diff strips...

Practical example of length matching



Serpentines may be worse than vias!



Cross-talk in vias

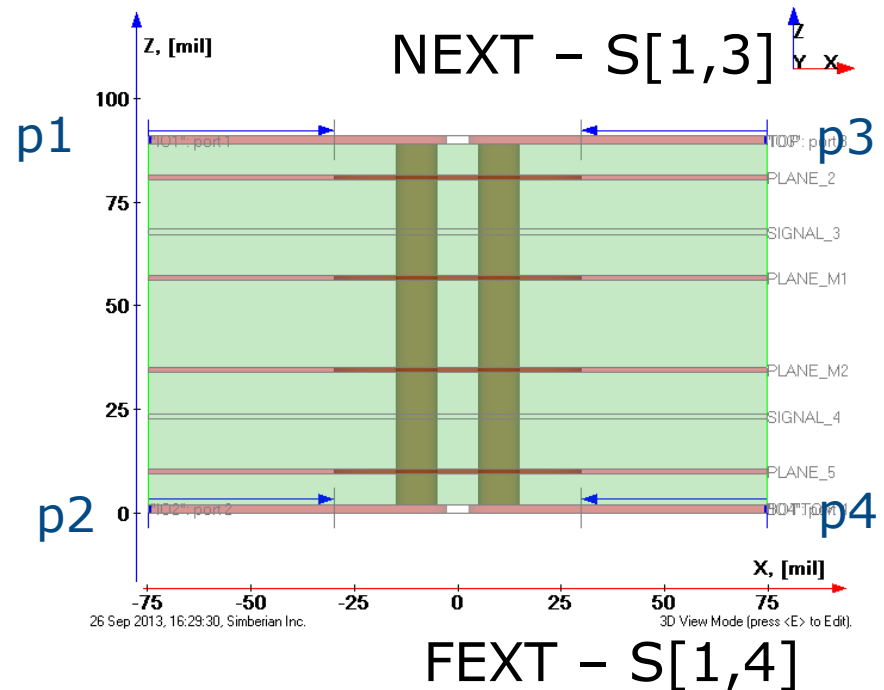
- 8-layer stackup from CMP-28 benchmark board from Wild River Technology, <http://wildrivertech.com>
- Dielectric and conductor models are identified with GMS-parameters

Materials: T=20[°C],...

- "1OZ_COPPER", RR=1, SR=0.32, RF=3.3, RM=Original
- "PLATED_1OZ_COPPER", RR=1, SR=0.32, RF=3.3, RM=MHCC
- "FR-408HR", Dk=3.83, LT=0.0117, PLM=WD, Dk(0)=4.29, Dk(inf)=3.63
- "Air"
- "Soldermask", Dk=3.7, LT=0.02, PLM=WD, Dk(0)=4.46, Dk(inf)=3.37

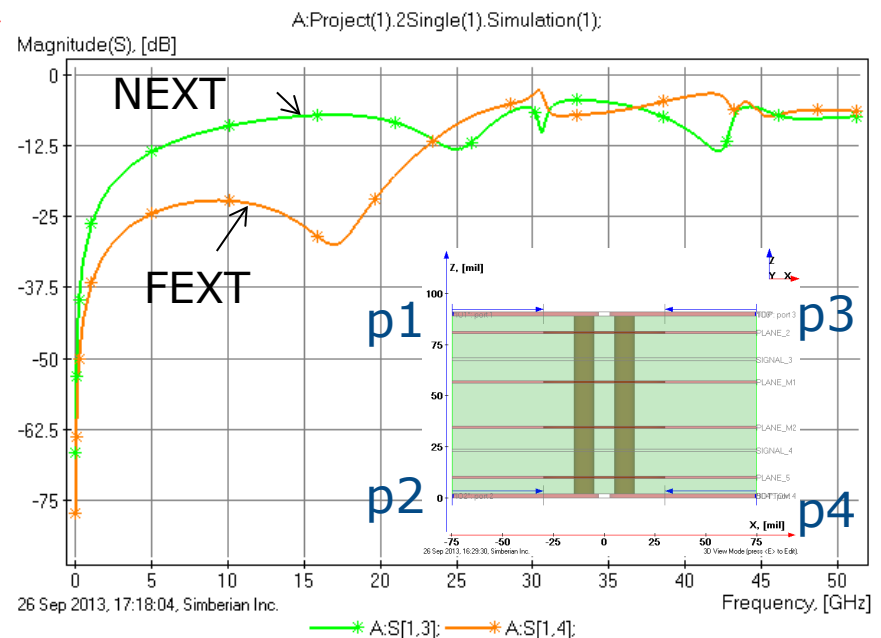
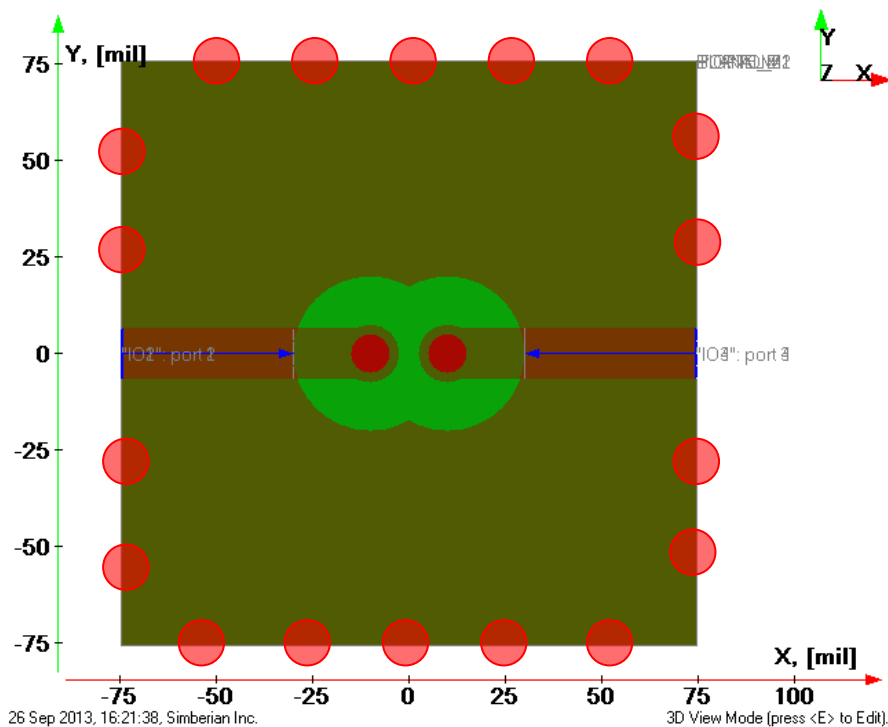
StackUp: LU=[mil], NL=8, T=91[mil], CSM=("Soldermask", 1.75[mil])

- 1 | Signal: "TOP", T=2, Ins="Air", Cond="PLATED_1OZ_COPPER"
- 2 | Medium: T=7.4, Ins="FR-408HR", DIE_003
- 3 | Plane: "PLANE_2", Cond="1OZ_COPPER", T=1.2, Ins="FR-408HR"
- 4 | Medium: T=12, Ins="FR-408HR", DIE_005
- 5 | Signal: "SIGNAL_3", T=1.2, Ins="FR-408HR", Cond="1OZ_COPPER"
- 6 | Medium: T=10, Ins="FR-408HR", DIE_007
- 7 | Plane: "PLANE_M1", Cond="1OZ_COPPER", T=1.2, Ins="FR-408HR"
- 8 | Medium: T=21, Ins="FR-408HR", DIE_008
- 9 | Plane: "PLANE_M2", Cond="1OZ_COPPER", T=1.2, Ins="FR-408HR"
- 10 | Medium: T=10, Ins="FR-408HR", DIE_009
- 11 | Signal: "SIGNAL_4", T=1.2, Ins="FR-408HR", Cond="1OZ_COPPER"
- 12 | Medium: T=12, Ins="FR-408HR", DIE_011
- 13 | Plane: "PLANE_5", Cond="1OZ_COPPER", T=1.2, Ins="FR-408HR"
- 14 | Medium: T=7.4, Ins="FR-408HR", DIE_013
- 15 | Signal: "BOTTOM", T=2, Ins="Air", Cond="PLATED_1OZ_COPPER"



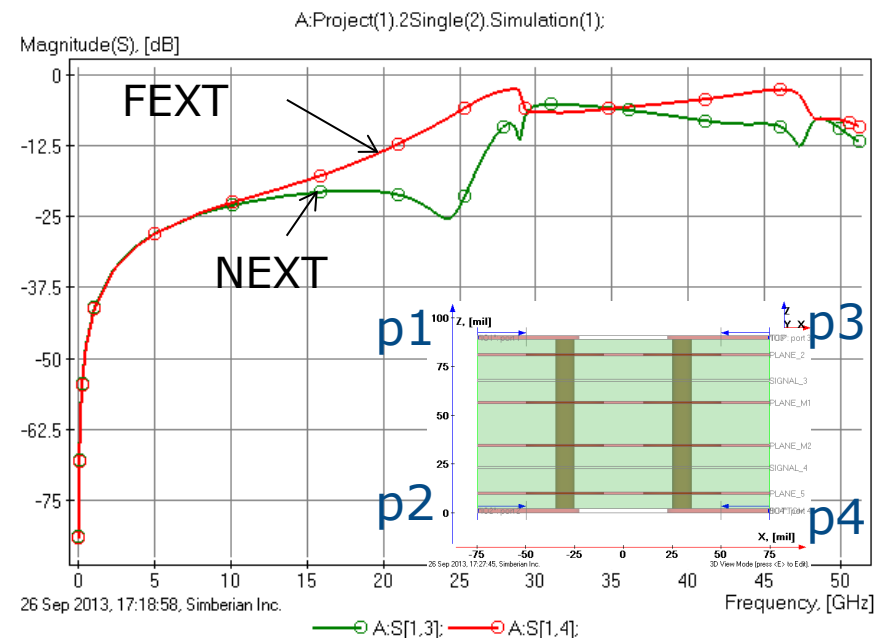
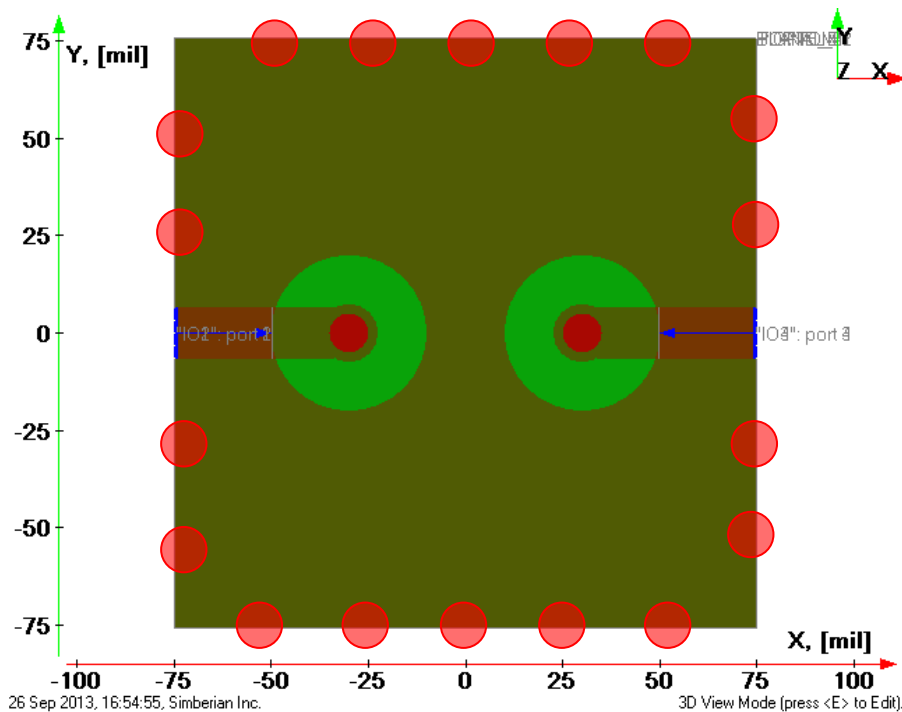
Single-ended vias – case 1

- Two coupled vias in a 150 x 150 mil area caged with PEC wall (stitching vias)
- Vias are 20 mil apart, antipad diameters 40 mil, 13 mil MSL;
- The first cage resonance is at about 10 GHz (half wavelength in dielectric)



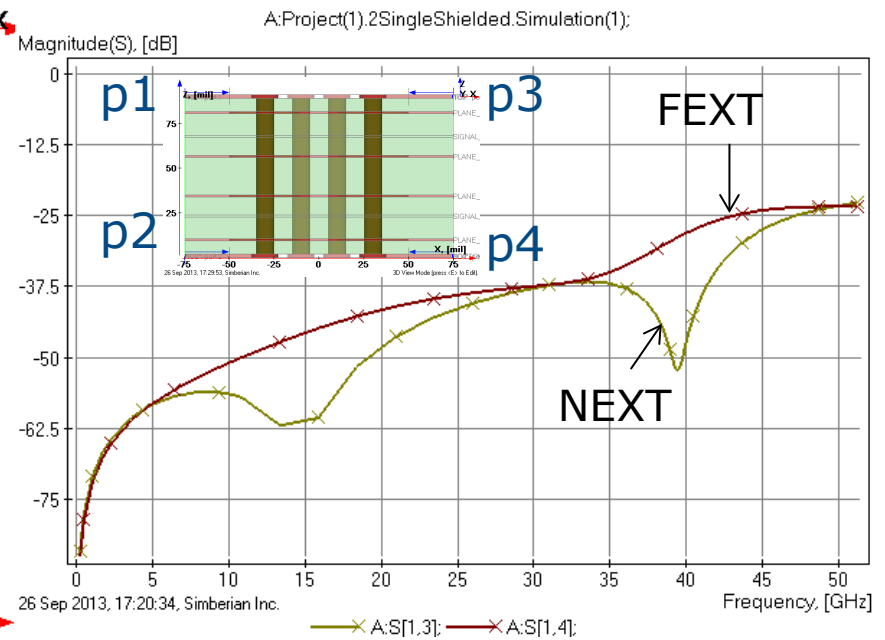
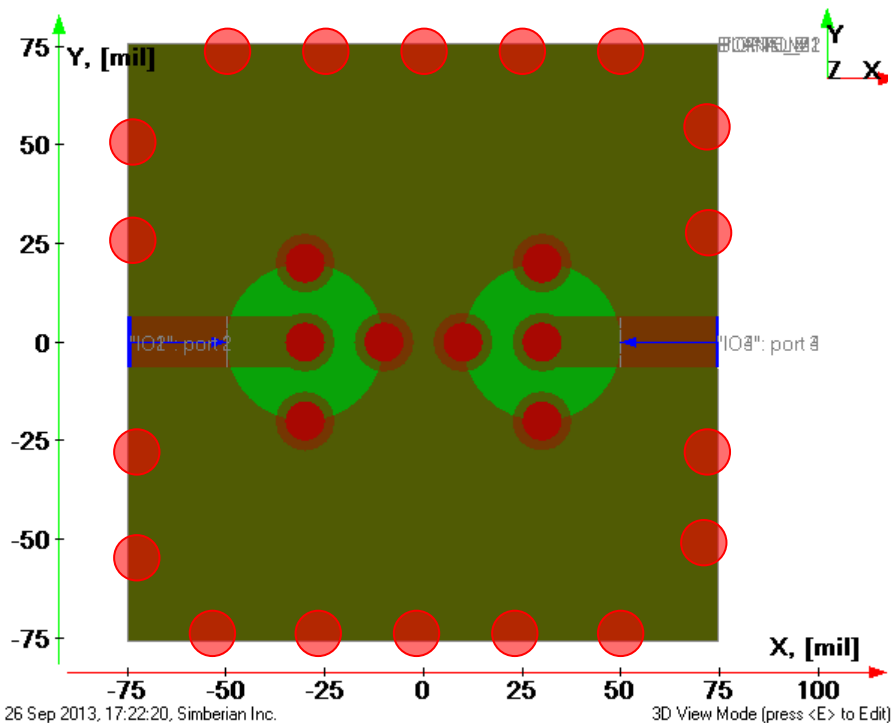
Single-ended vias – case 2

- Two un-coupled vias in a 150 x 150 mil area caged with PEC wall (stitching vias)
- Vias are 60 mil apart, antipad diameters 40 mil
- Separation reduced NEXT below 25 GHz, but FEXT is increased above 10 GHz – vias are coupled through the cavity (may be the whole board)!



Single-ended vias – case 3

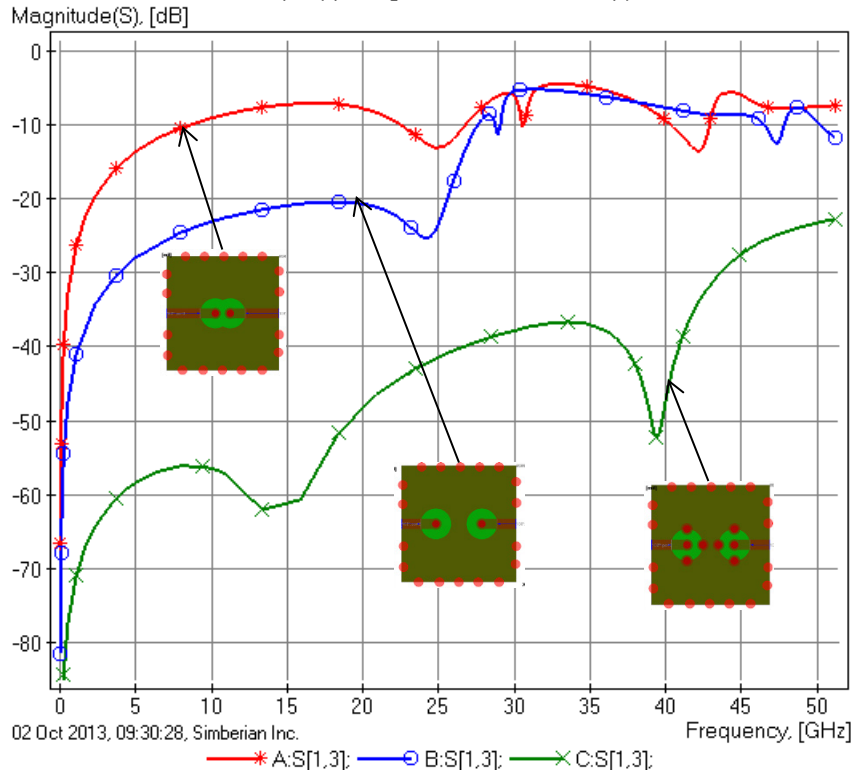
- Two shielded vias in a 150 x 150 mil area caged with PEC wall (stitching vias)
- Vias are 60 mil apart, antipad diameters 40 mil, stitching vias are 20 mil from the signal vias – localized up to about 30 GHz
- No cross-talk due to the localization – also models for such vias do not depend on the caging or simulation area!



Cross-talk in single-ended vias

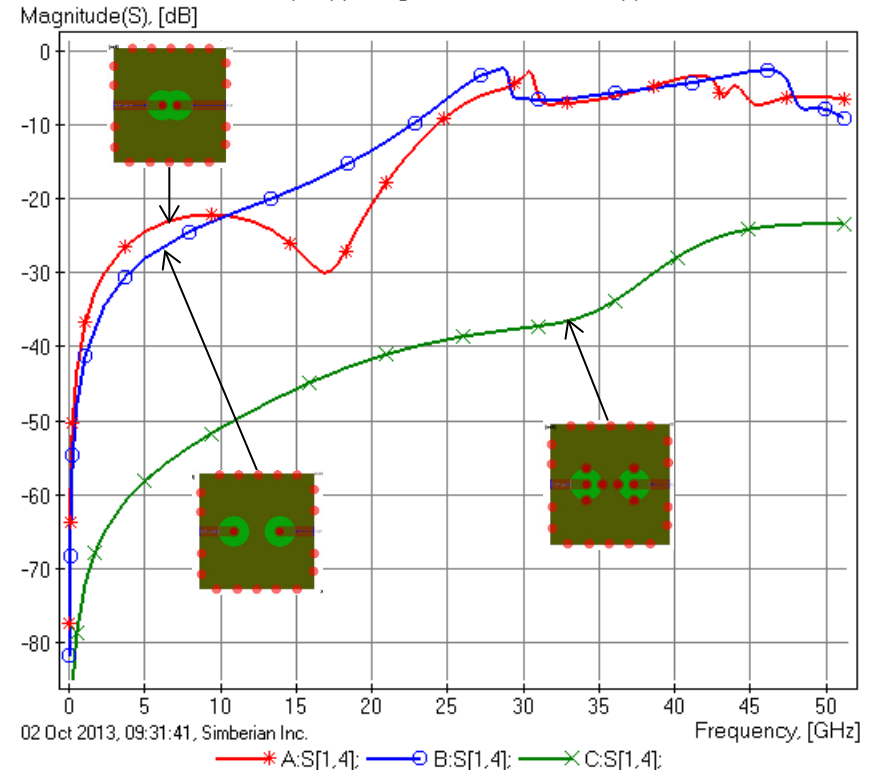
NEXT

A:Project(1).2Single(1).Simulation(1); B:Project(1).2Single(2).Simulation(1);
C:Project(1).2SingleShielded.Simulation(1);

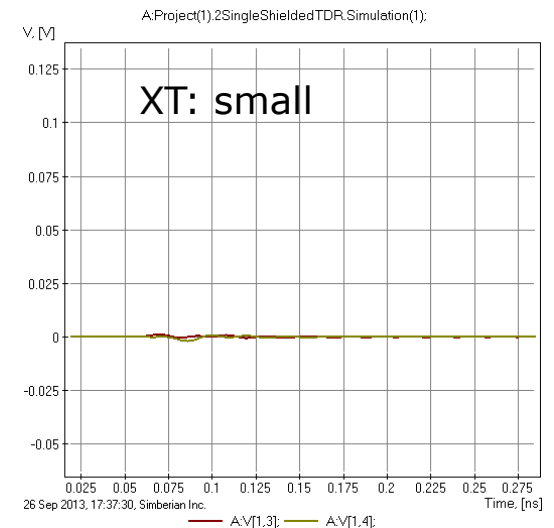
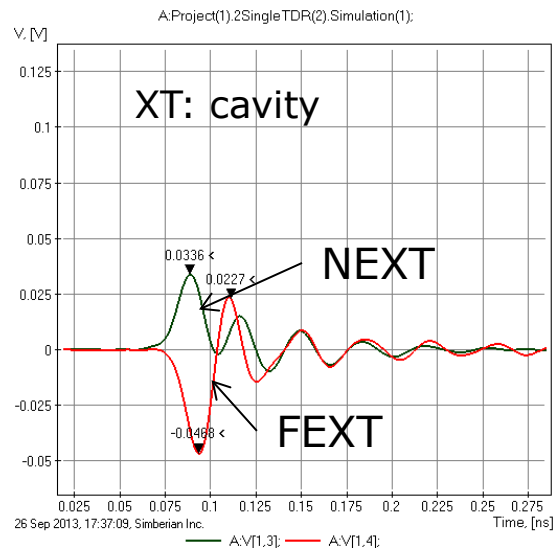
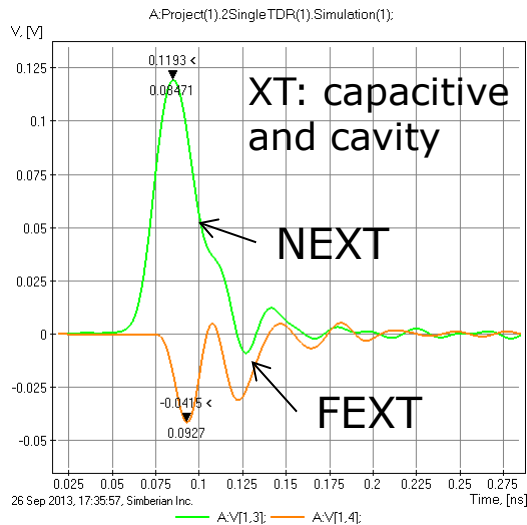
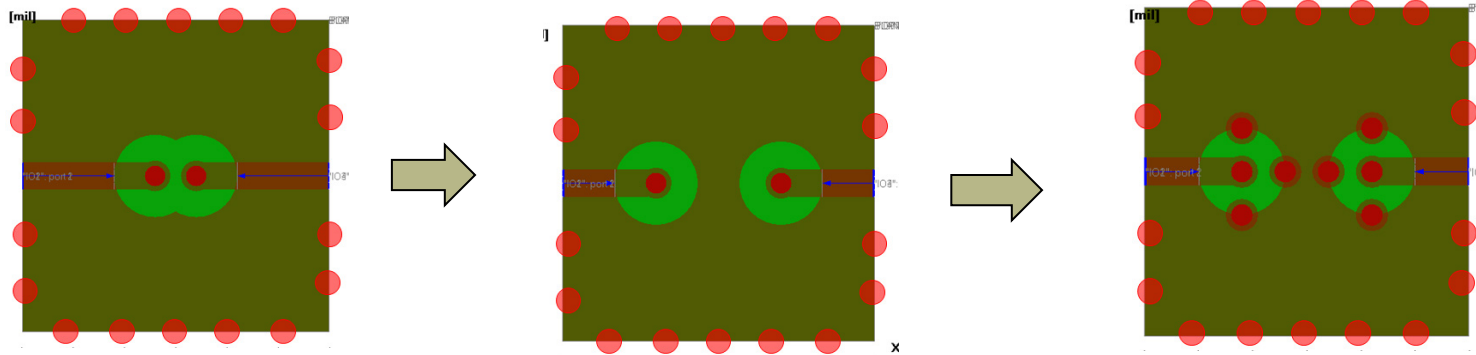


FEXT

A:Project(1).2Single(1).Simulation(1); B:Project(1).2Single(2).Simulation(1);
C:Project(1).2SingleShielded.Simulation(1);



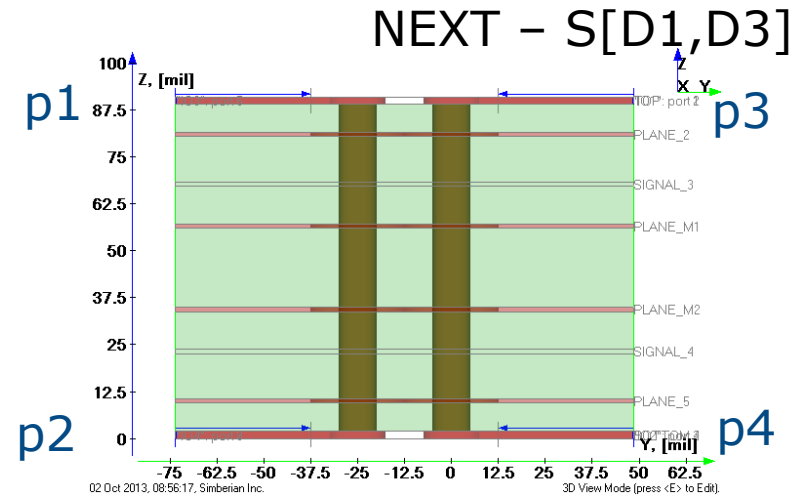
SE vias cross-talk on TDT: 0.5 V, 16 ps Gaussian step



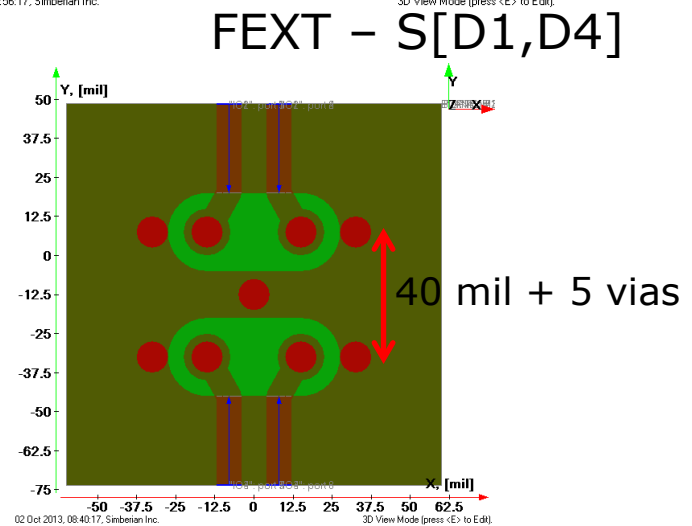
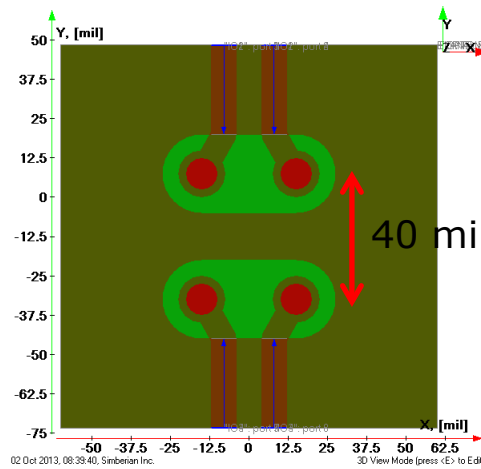
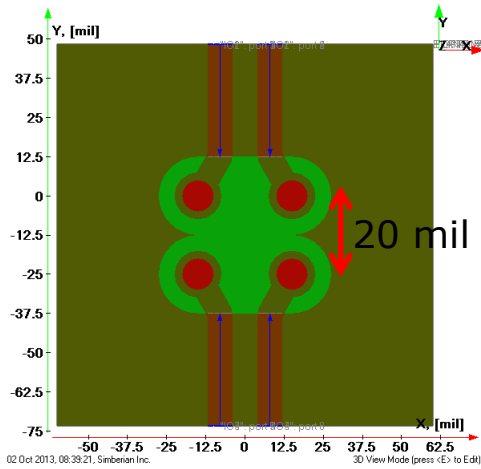
Are localized vias also optimal? – see FRSI via x-talk example at www.kb.simberian.com

Cross-talk in differential vias

Two coupled differential vias in a 120 x 120 mil area caged with PEC wall
 Vias are 30 mil apart, antipad 25x55 mil, traces 8 mil MSL, 8 mil separation;
 The first cage resonance is at about 12 GHz (half wavelength in dielectric)
 Stackup from CMP-28 board, Wild River Technology <http://wildrivertech.com>



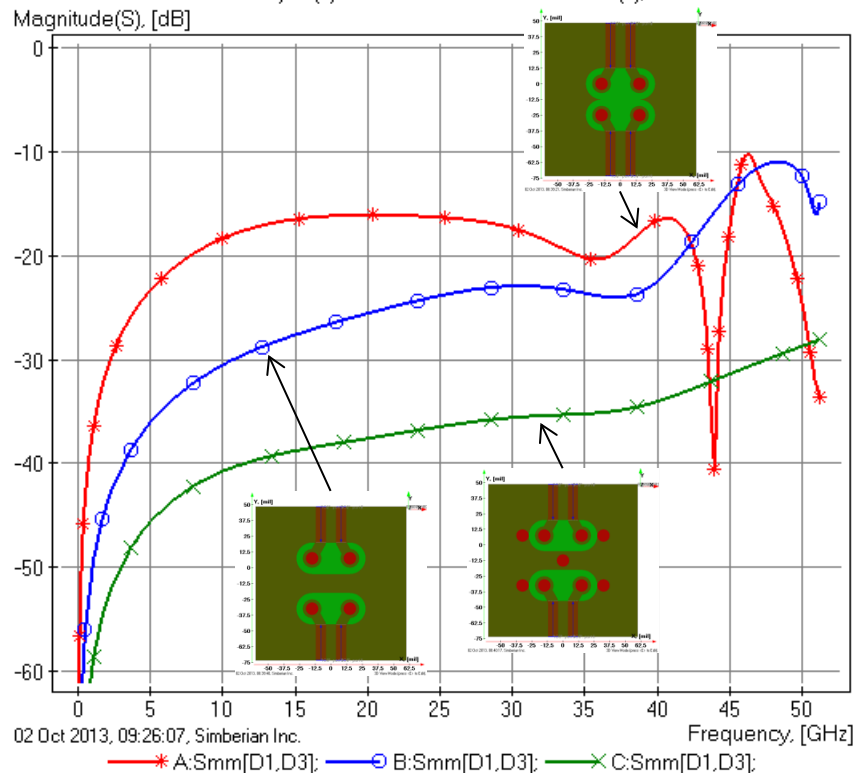
Three cases:



Cross-talk in differential vias

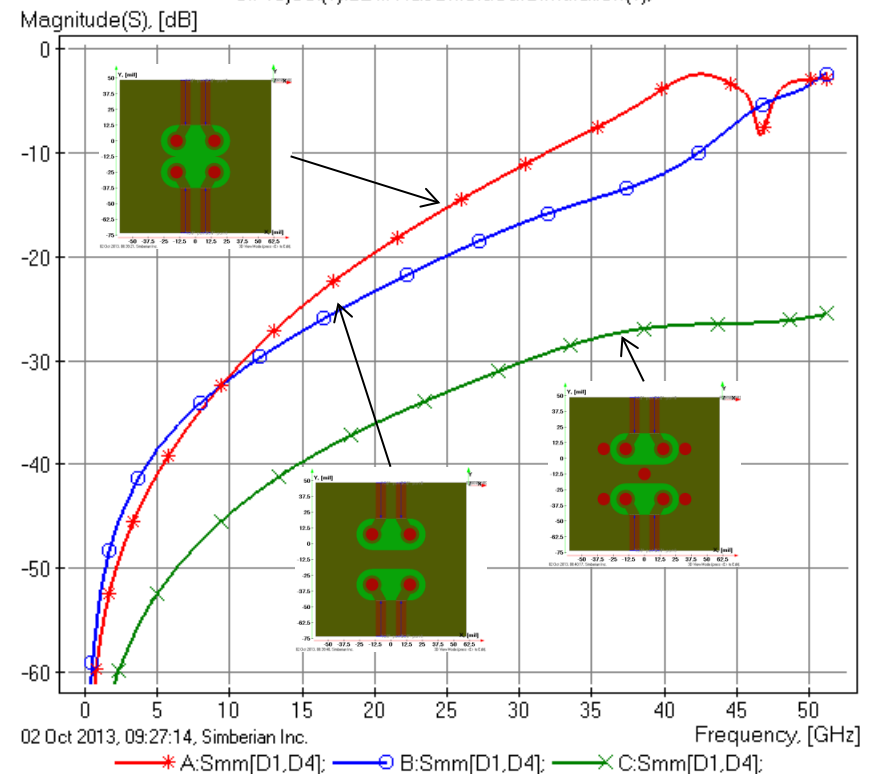
NEXT

A:Project(1).2DiffVias(1).Simulation(1); B:Project(1).2DiffVias(2).Simulation(1);
C:Project(1).2DiffViasShielded.Simulation(1);

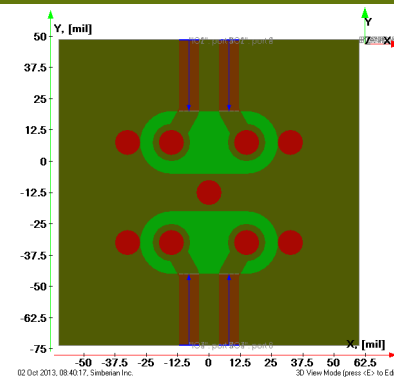
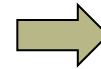
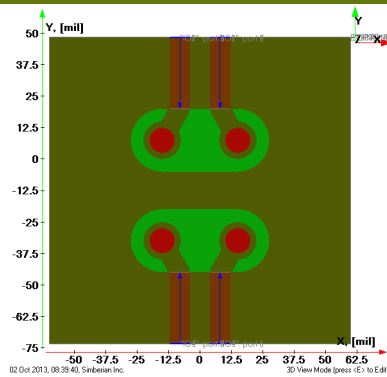
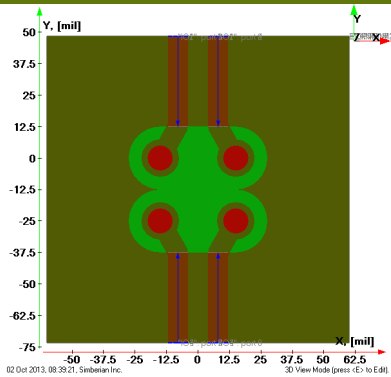


FEXT

A:Project(1).2DiffVias(1).Simulation(1); B:Project(1).2DiffVias(2).Simulation(1);
C:Project(1).2DiffViasShielded.Simulation(1);



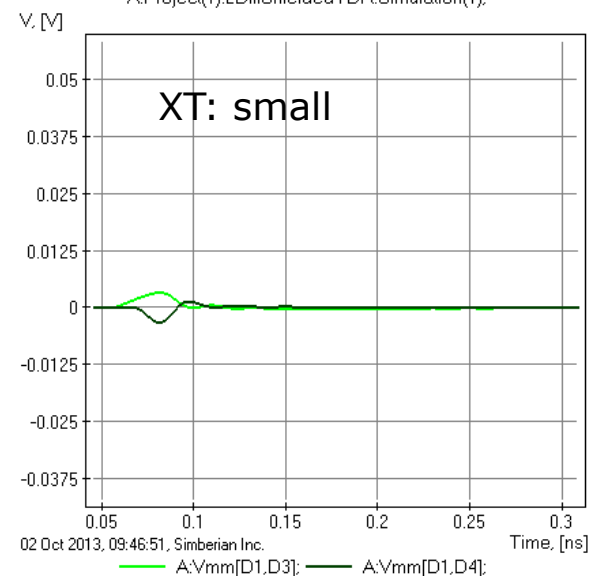
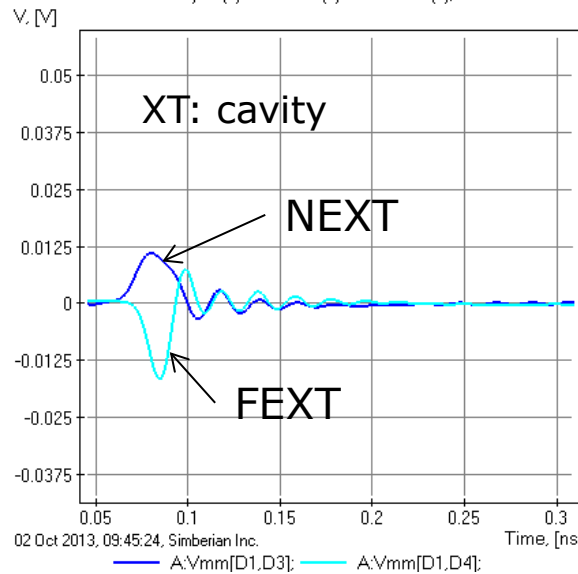
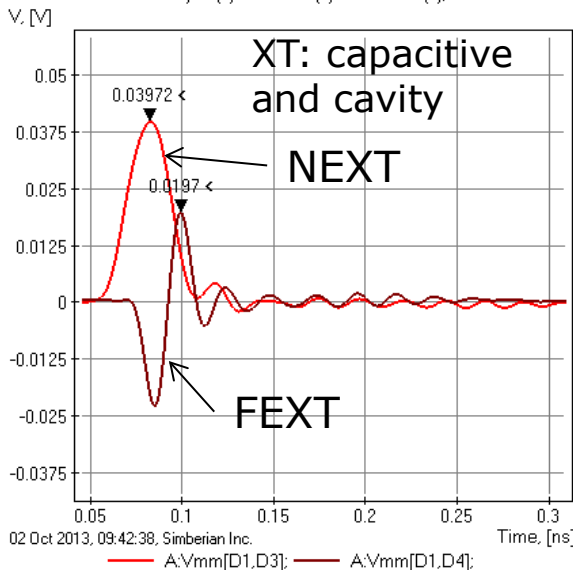
Differential vias cross-talk on TDT: 0.5 V, 16 ps Gaussian step



A:Project(1).2DiffTDR(1).Simulation(1);

A:Project(1).2DiffTDR(2).Simulation(1);

A:Project(1).2DiffShieldedTDR.Simulation(1);



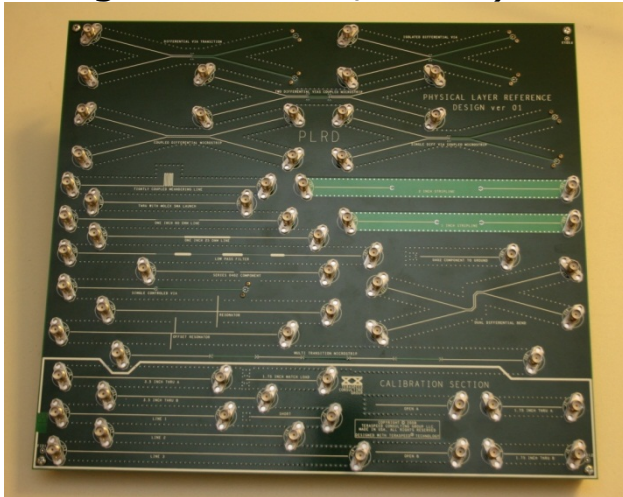
Are localized vias also optimal? – see FRSI via x-talk example at www.kb.simberian.com

Benchmarking or validation

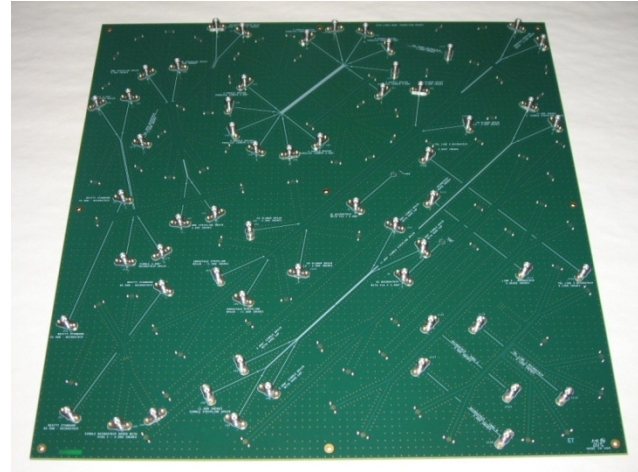
- How to make sure that the analysis works? – Validation boards!
- **Consistent board manufacturing is the key for success**
 - Fiber type, resin content, copper roughness must be strictly specified or fixed!!!
- Include a set of structures to identify one material model at a time
 - Solder mask, core and prepreg, resin and glass, roughness, plating,...
- Include a set of structures to identify accuracy for transmission lines and typical discontinuities
 - Use identified material models for all structures on the board consistently
 - No tweaking - discrepancies should be investigated
- Use VNA/TDNA measurements and compare both magnitude and phase (or group delay) of all S-parameters

Example of benchmarking boards

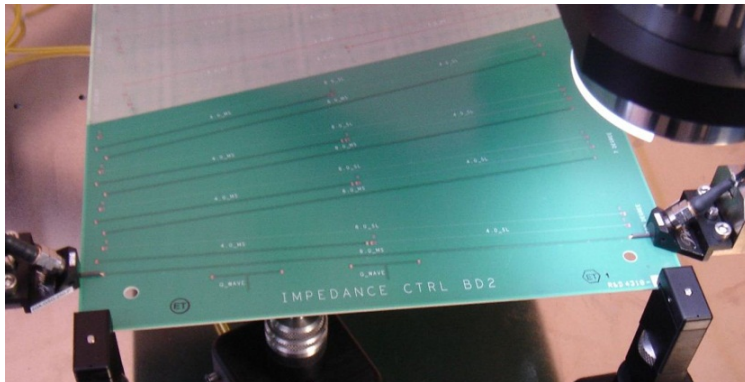
PLRD-1 (Teraspeed Consulting,
DesignCon 2009, 2010)



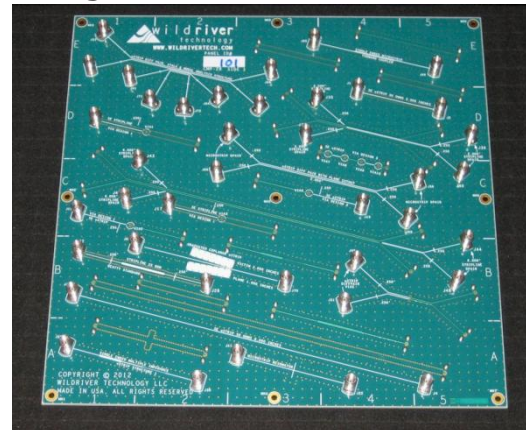
CMP-08 (Wild River Technology &
Teraspeed Consulting, DesignCon 2011)



Isola, EMC 2011, DesignCon 2012



CMP-28, Wild River Technology,
DesignCon 2012



Conclusion

- Validate all ideas with EM analysis
- **Build only things that can be reliably analyzed!**
- Decompositional analysis is the fastest and most accurate way to simulate interconnects ONLY IF
 - All S-parameter models in the link are qualified
 - Material parameters are properly identified
 - Interconnects are designed as localized waveguides
 - Manufacturer, measurements and models are benchmarked
- Examples created for this presentation are available at www.kb.simberian.com (use FRSI keyword)

Contact and resources

- ❑ Yuriy Shlepnev, Simberian Inc.,
shlepnev@simberian.com
Tel: 206-409-2368
- ❑ **Webinars on decompositional analysis, S-parameters quality and material identification** <http://www.simberian.com/Webinars.php>
- ❑ Simberian web site and contacts www.simberian.com
- ❑ Demo-videos <http://www.simberian.com/ScreenCasts.php>
- ❑ App notes <http://www.simberian.com/AppNotes.php>
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